

Spatially Resolved Acoustic Spectroscopy (SRAS)

“Sight Through Sound”

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DURIP N00014-17-1-2294

Baseline: This is a microscope

Leeuwenhoek's work defines our definition:

"To see small..."

- A more complete technical description of a microscope is:
 - An instrument which
 - uses optics to direct a beam of EM radiation to
 - a specimen that is of interest where
 - the incident waves are modified by certain characteristics of the specimen
 - and for which the modified waves/particles are directed to a detector for analysis (with it's own signal modification)

Let's test this

Optical (including Leeuwenhoeks)

Optics	Uses optics to direct a beam of EM radiation to	Light (coherent or incoherent)
Specimen Damage	a specimen that is of interest where	✓
Image Theory	the incident waves are modified by certain characteristics of the specimen	Reflection Transmission
Detectors	and for which the modified waves/particles are directed to a detector for analysis	✓ (from an observer to detectors)

SRAS is a microscopy technique that directs energy impulses (typically supplied by a laser) to the specimen, and which are sufficient to interact and generate acoustic waves (of varying modes) which can be measured using sophisticated detectors.

Interestingly, this structure (optics, specimen/damage, theory, detectors) are where most microscope developers and users spend all their time.

Spatially Resolved Acoustic Spectroscopy

Motivation for the work:

Sometimes, we need data and statistics as the mesoscale!

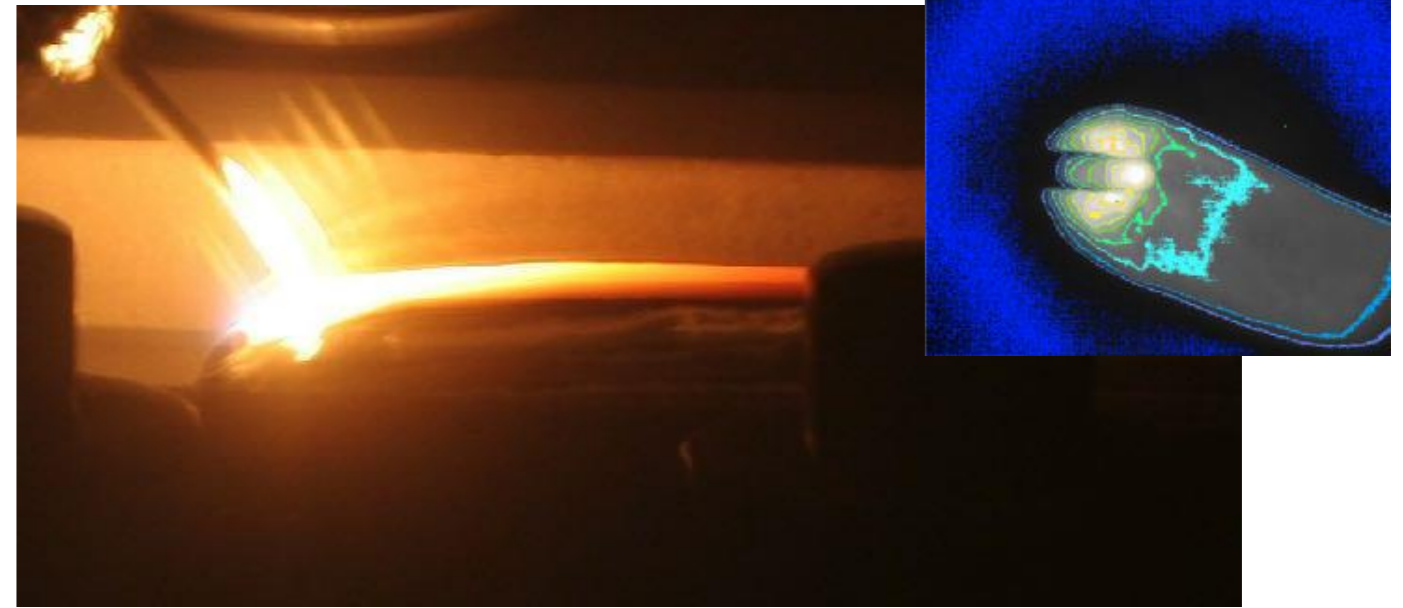
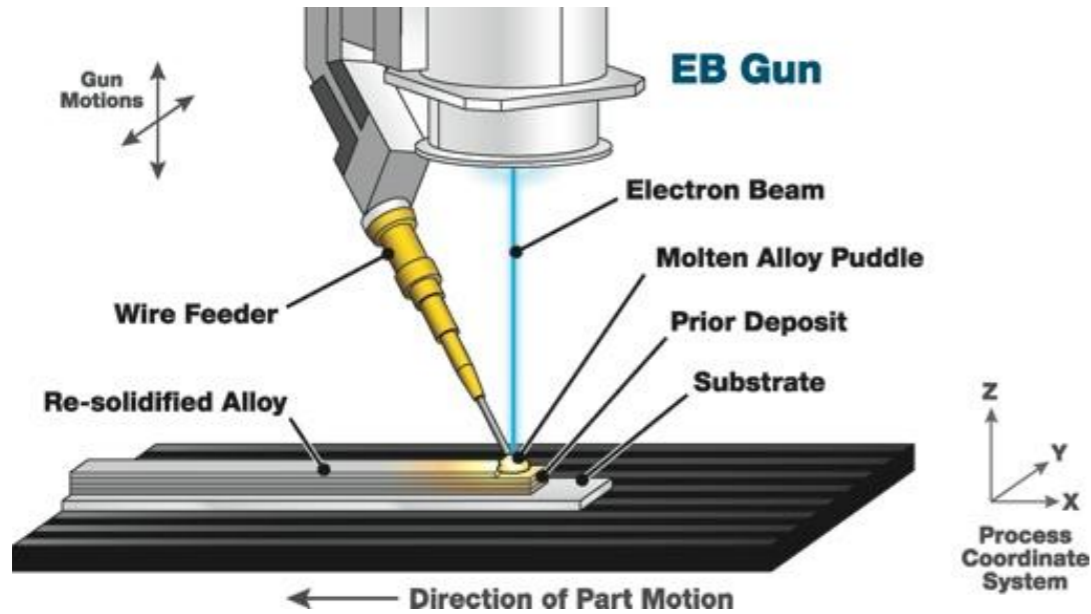
“Failure is central to engineering. Every single calculation that an engineer makes is a failure calculation. Successful engineering is all about understanding how things break or fail.” --- Henry Petroski

SRAS Basics

Our first data

Possibilities, probabilities, and limitations

Motivation, part I: *Texture in Large-Scale AM*



2012 AeroMat presentation: "F-35 Direct Manufacturing: Material Qualification Results" June 20, 2012

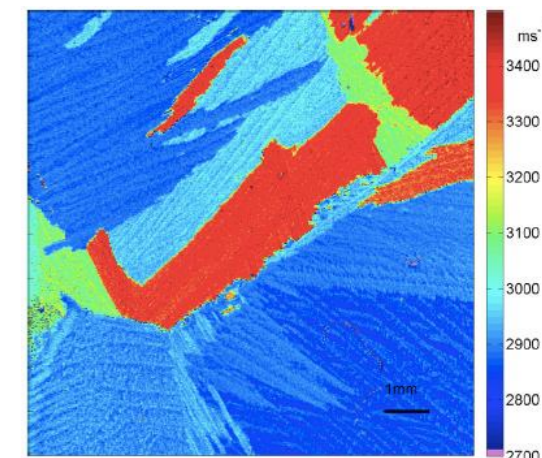
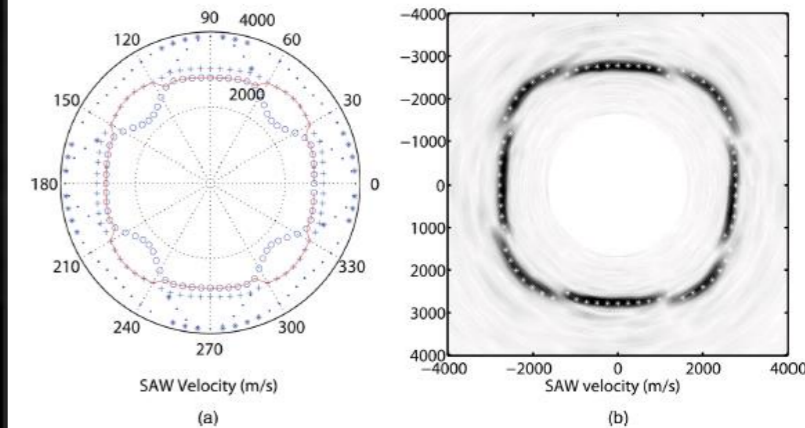
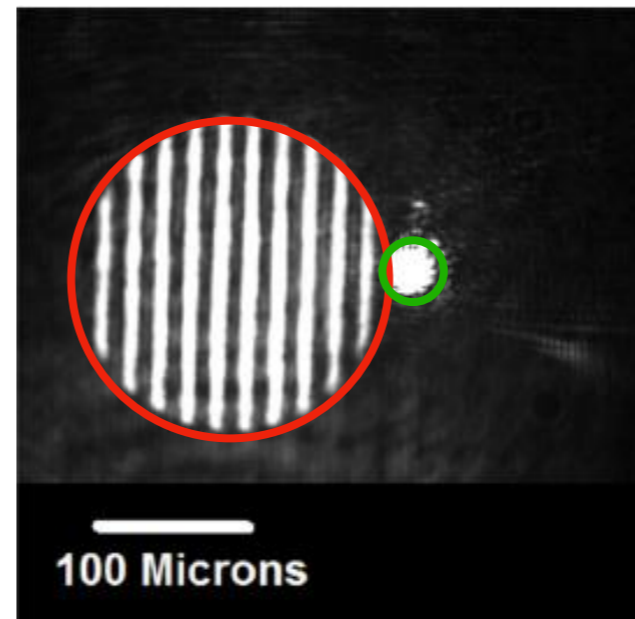
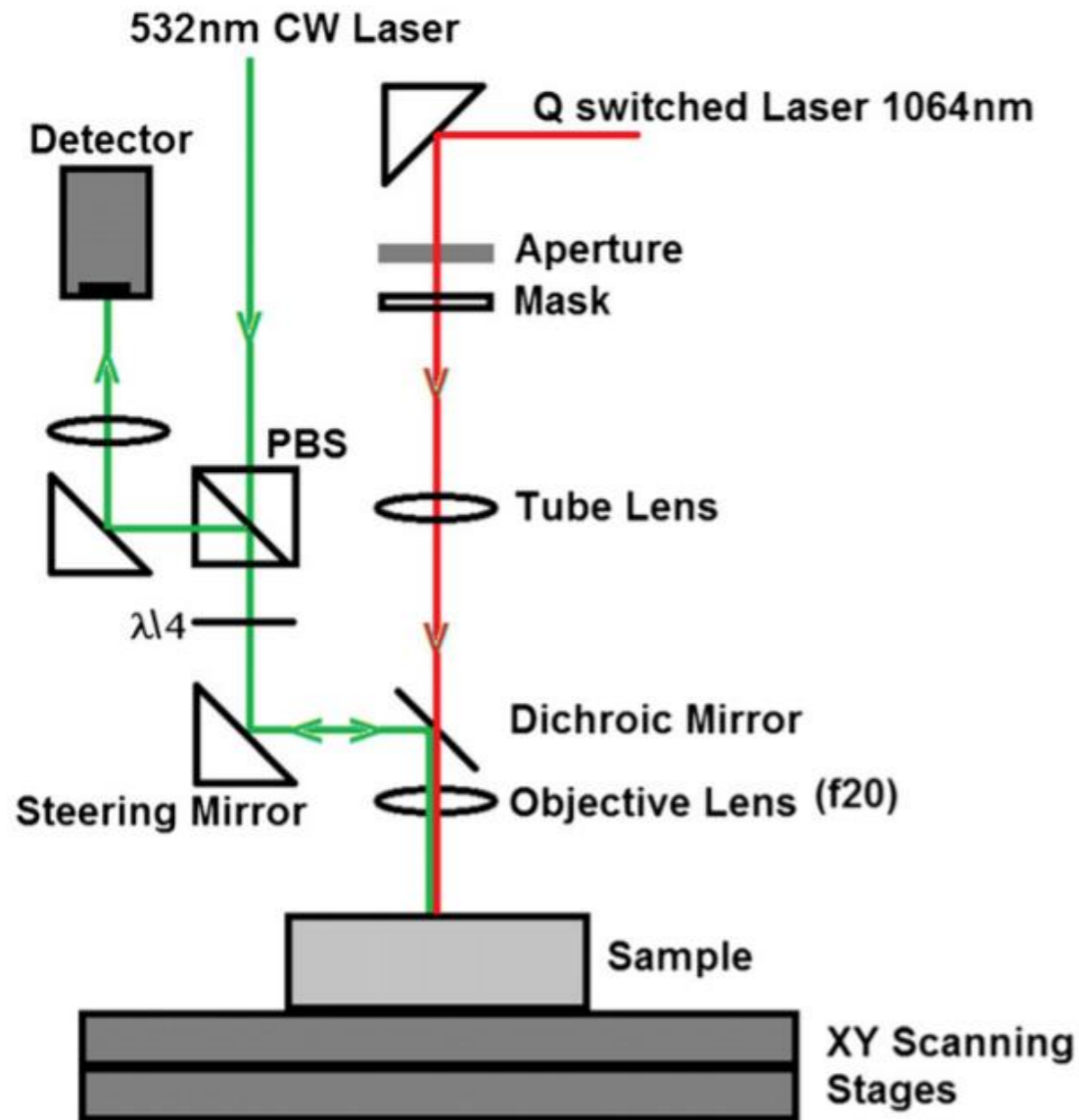


Motivation, part II: Microtexture?



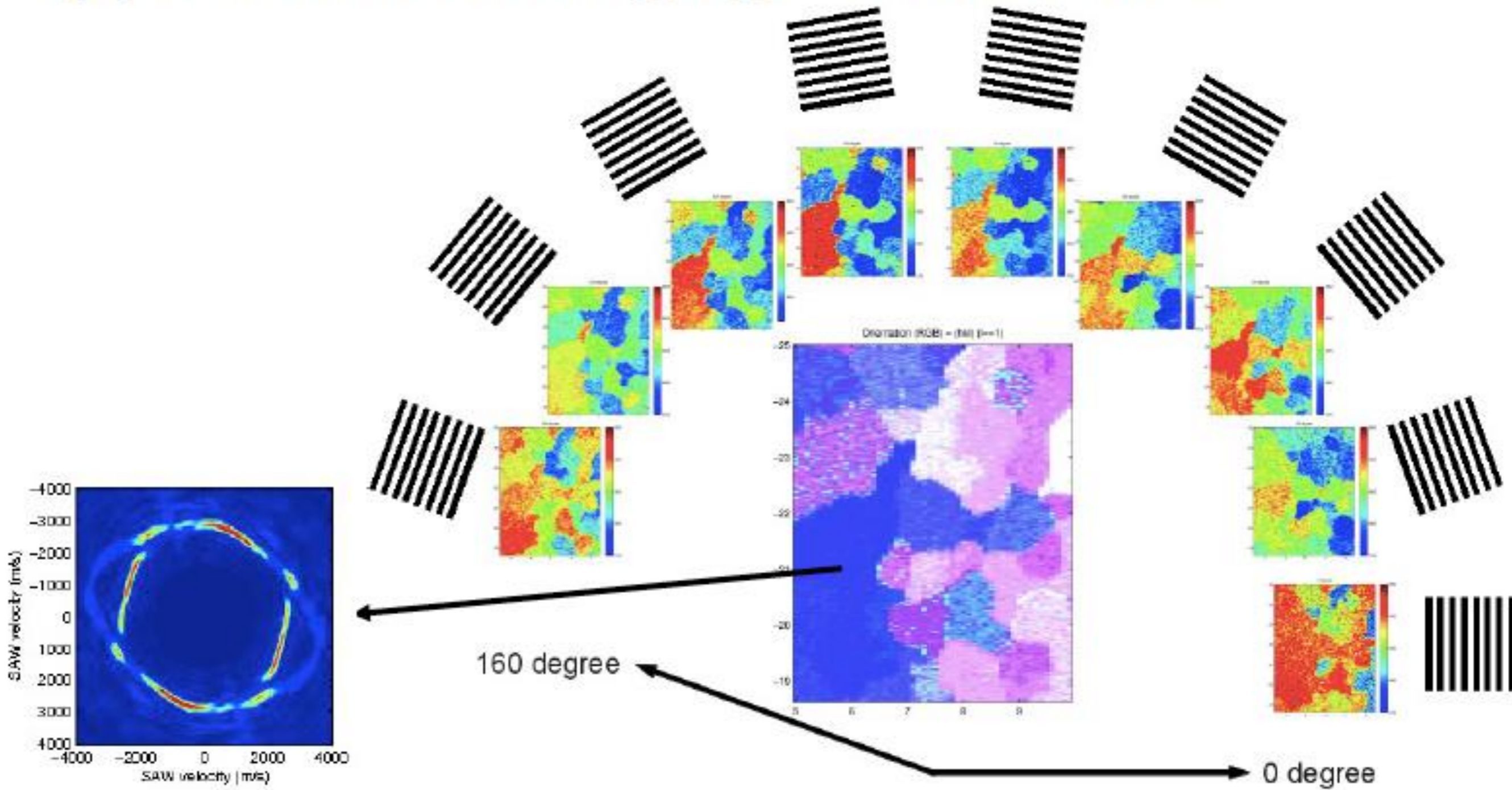
Spatially Resolved Acoustic Spectroscopy

- Laser UT Technique
- Able to detect velocity of SAWs (*~Mach 9*)
- Can determine crystallographic information through detection of *nm-level surface displacements*
- Data is then coupled with simulation data of multiple wave modes (governed by the elastic stiffness tensor, C_{ijkl})
- EBSD-like data with restrictions



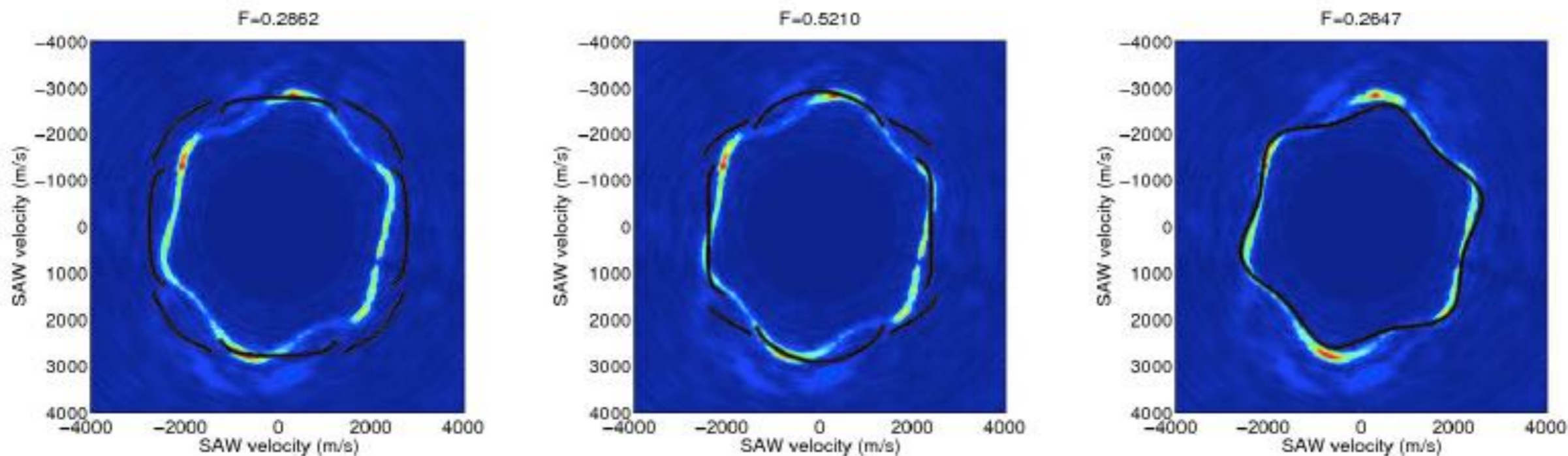
“Spatially resolved acoustic spectroscopy for rapid imaging of material microstructure and grain orientation,” Richard J Smith et al, 2014, Meas. Sci. Technol. **25** 055902 DOI: 10.1088/0957-0233/25/5/055902

(2) Orientation imaging – Collect data

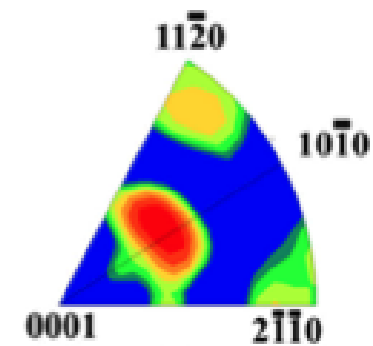
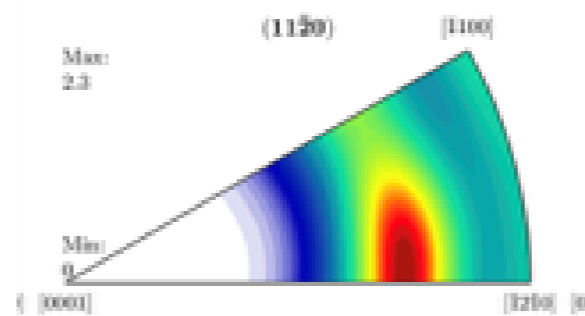
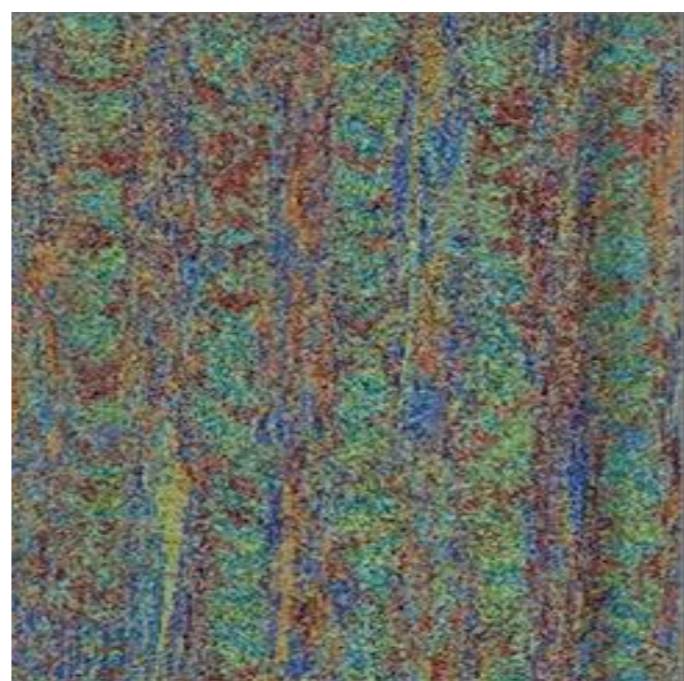
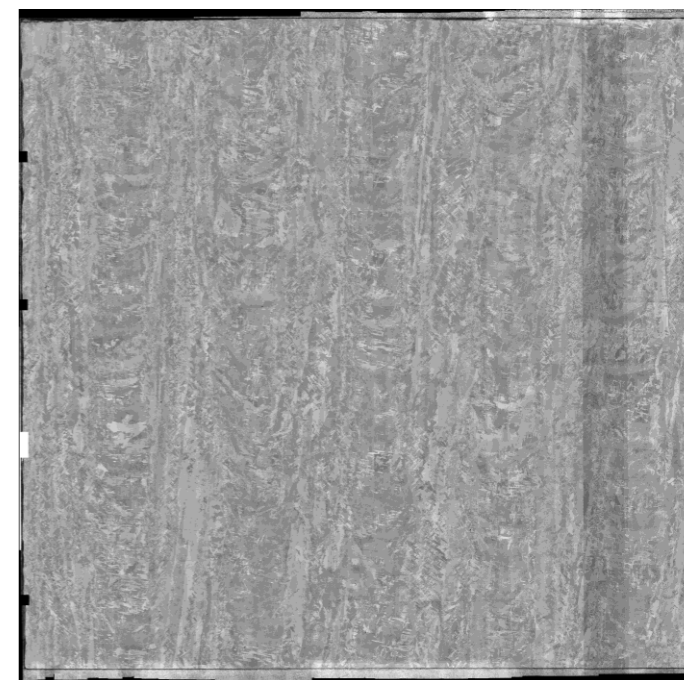
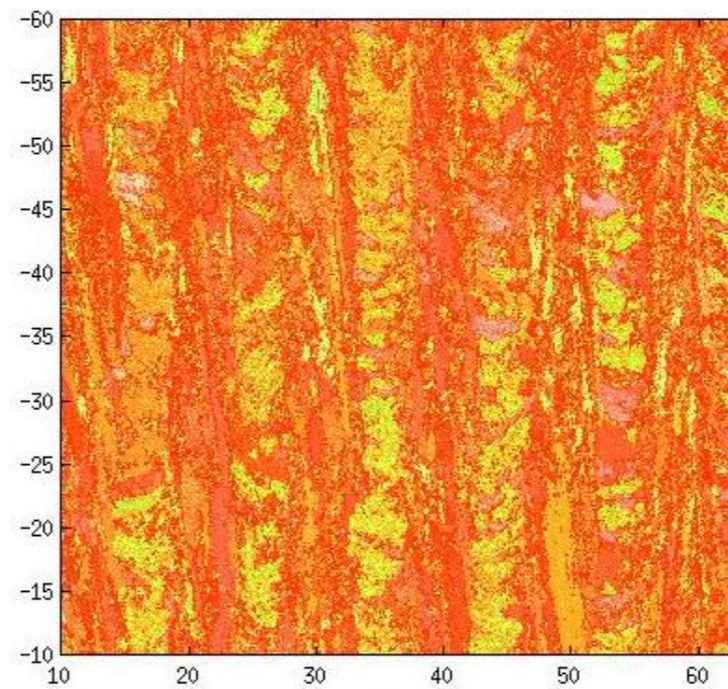
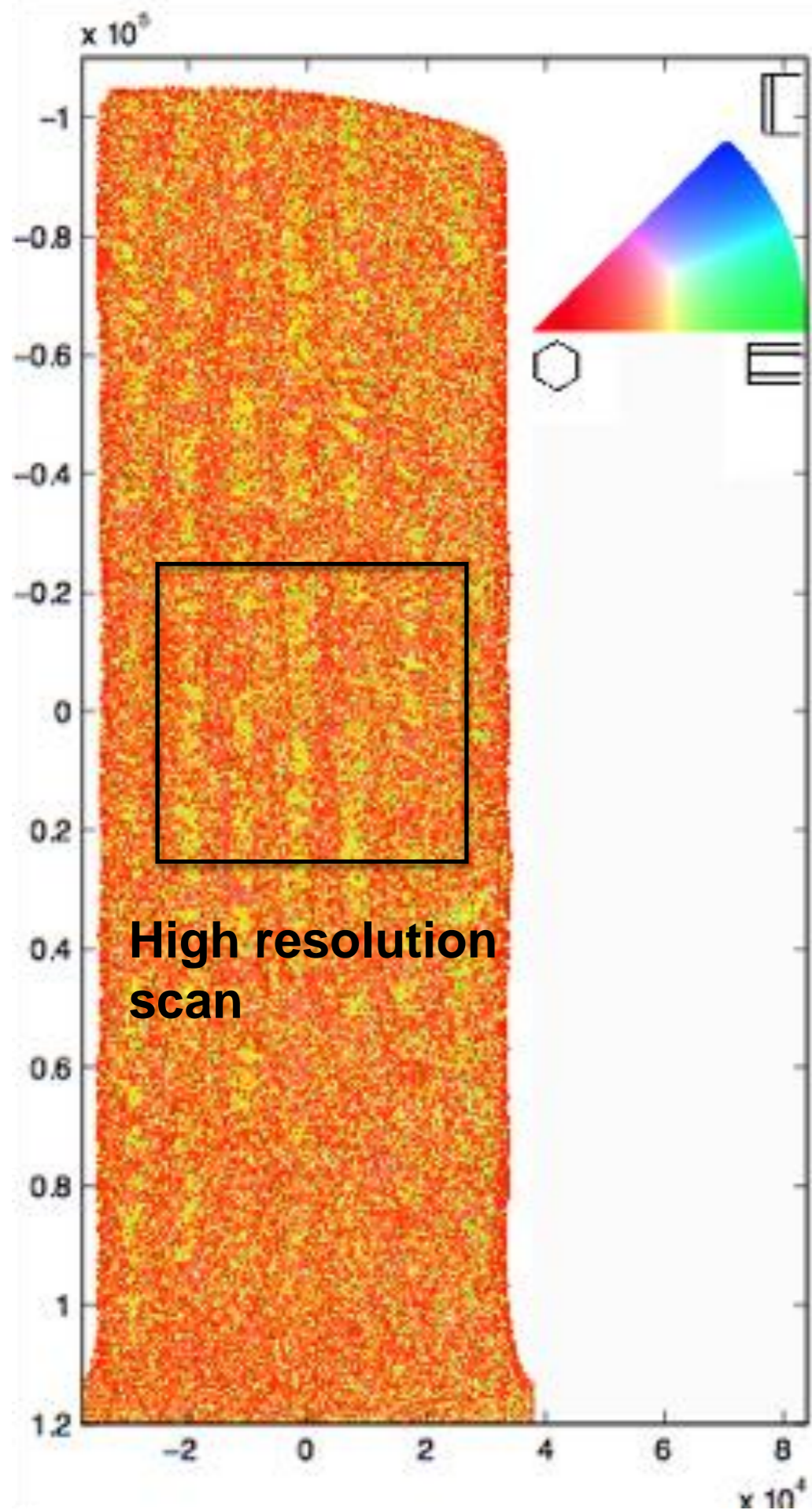


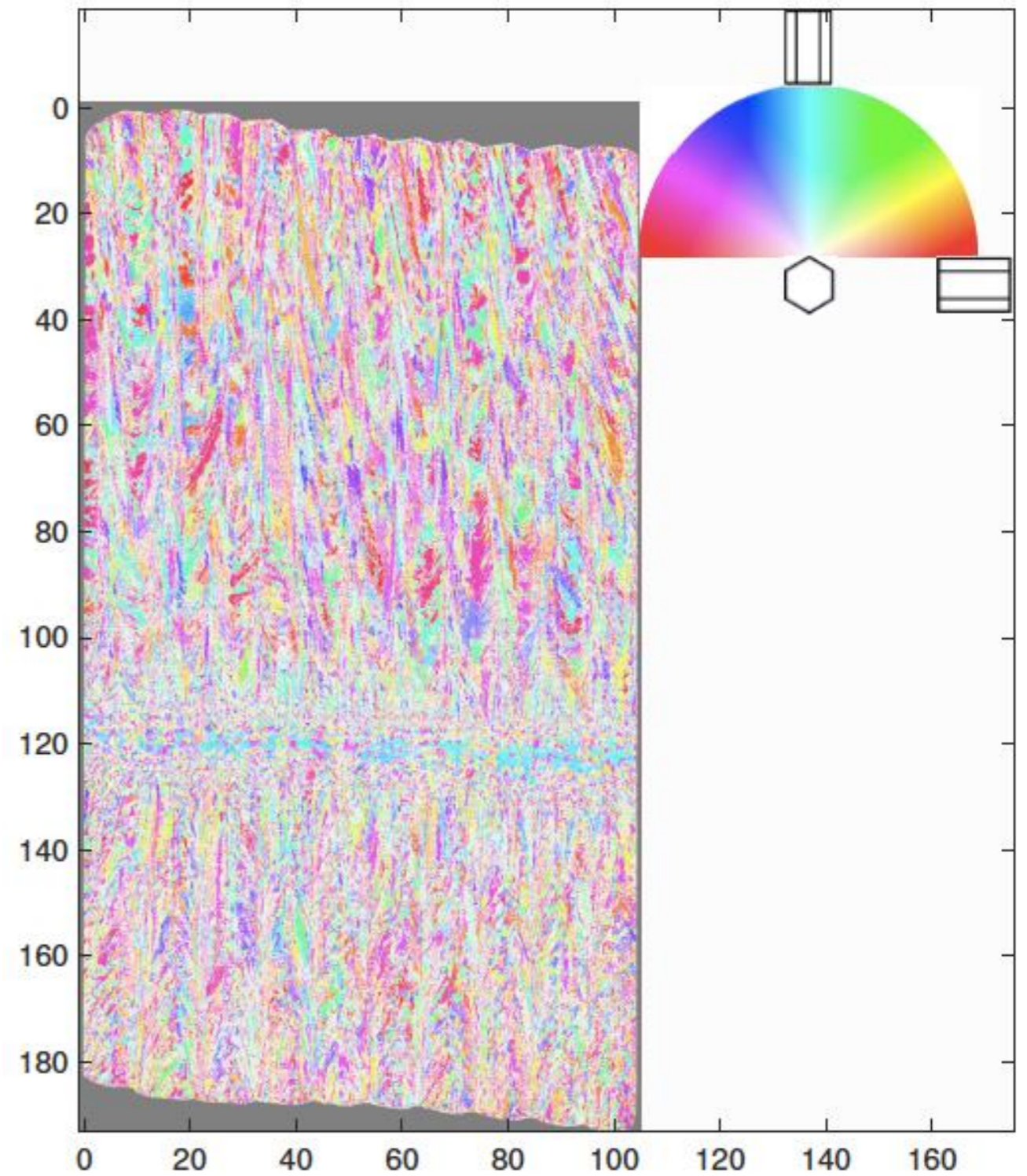
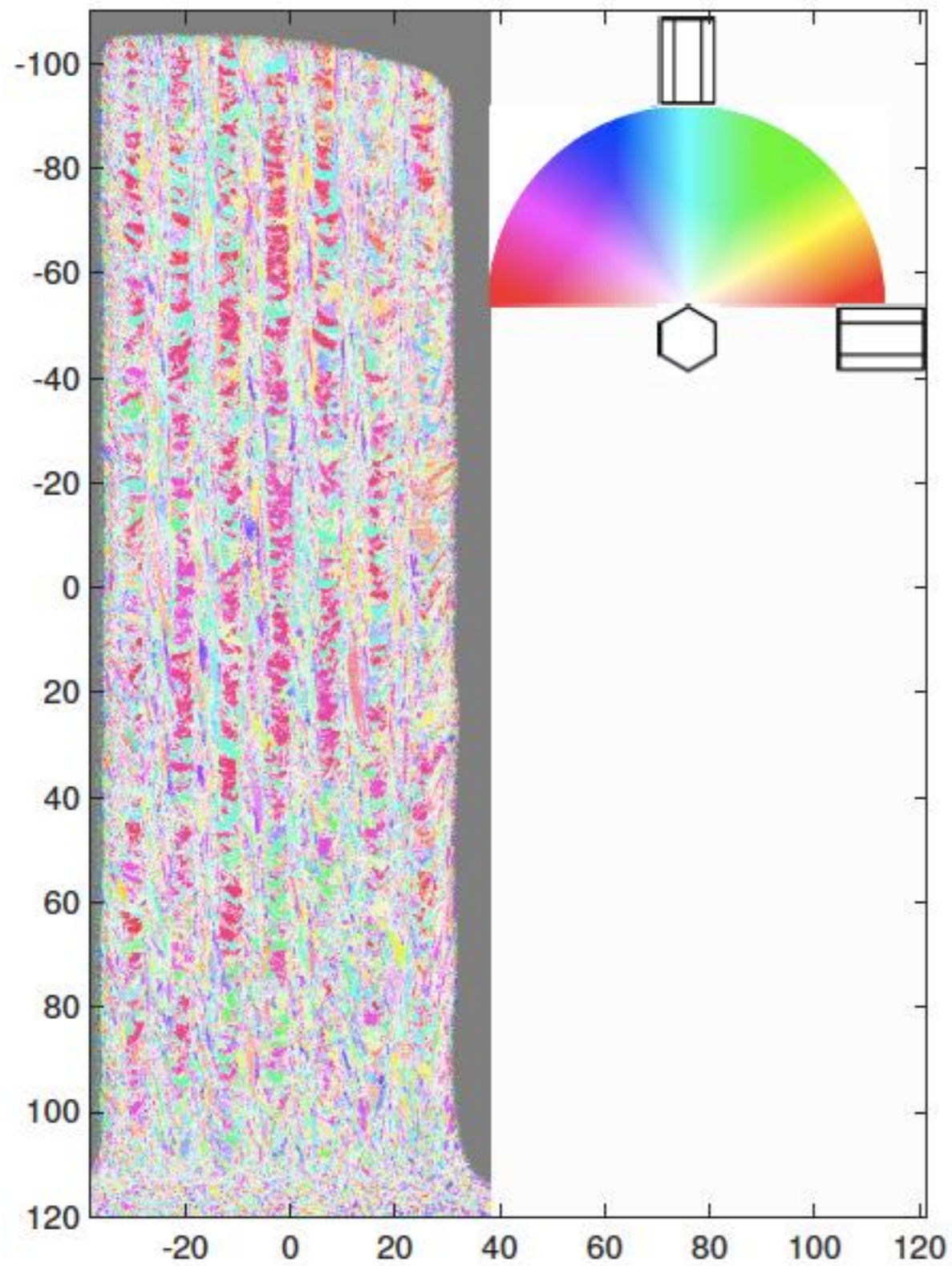
(3) Orientation imaging - fit to data

$$F(h, k, l, \theta) = \sum_{\phi=0}^{\phi=\frac{n-1}{n}\pi} A(\phi, v_{(h,k,l,(\phi-\theta))}), \quad (n = 1, 2, 3, \dots)$$



- ▶ The merit function is simply the sum of the amplitude under the black asterisks on the graph
- ▶ Repeat this procedure for all the combinations of plane and propagation direction





In these two scans, we may have more orientation data than all EBSD scans of AM Ti-6Al-4V combined.

So, let's make a SRAS system...

...but let's integrate it into a serial
sectioning tool

(as if SRAS is not hard enough)



With credit given to:
The Art of Electronics (Horowitz & Hill)

Robot 2

Optical
Microscope

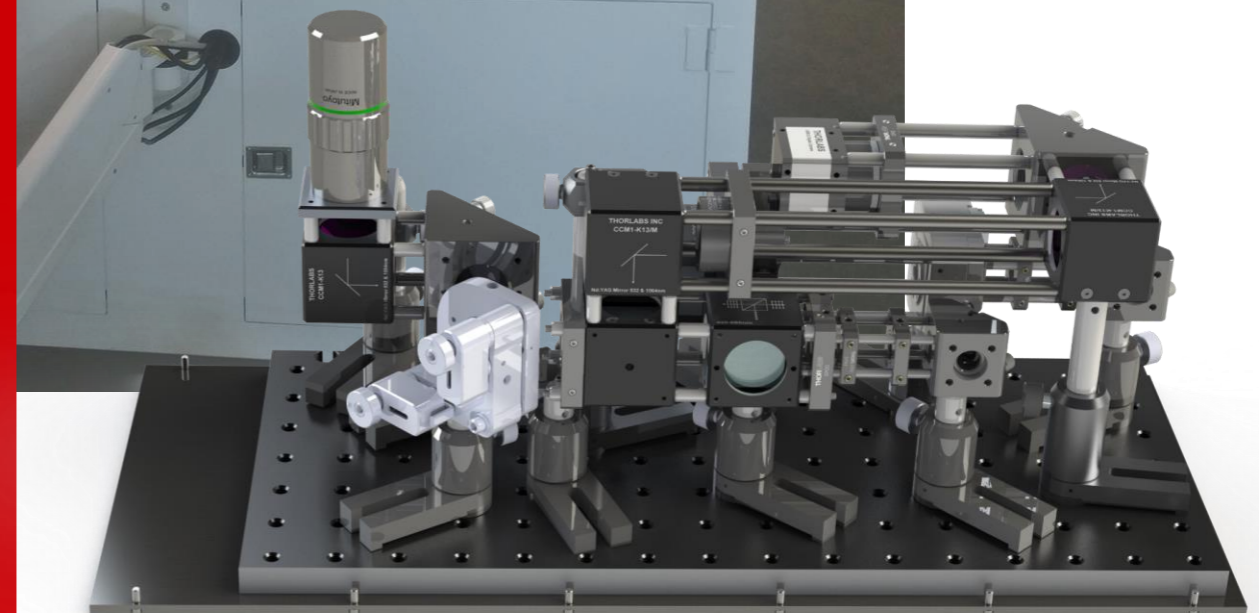
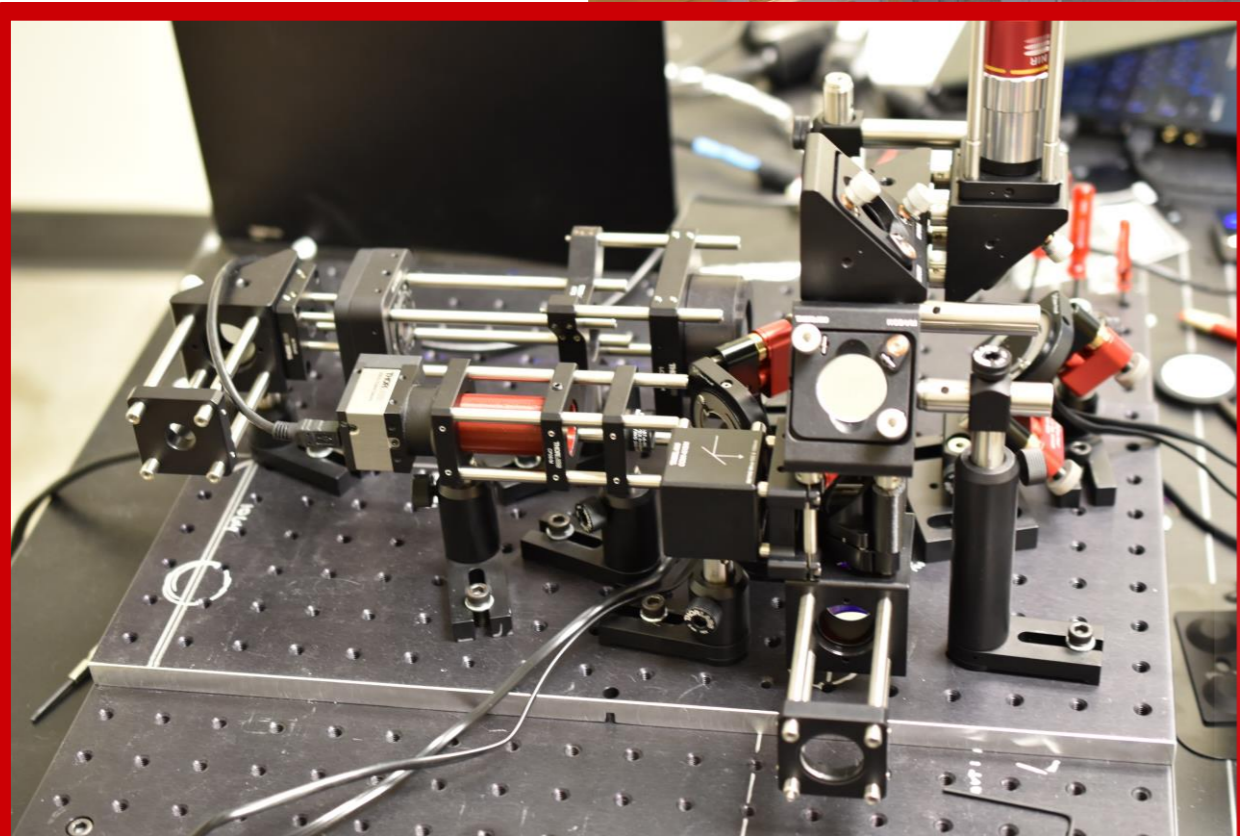
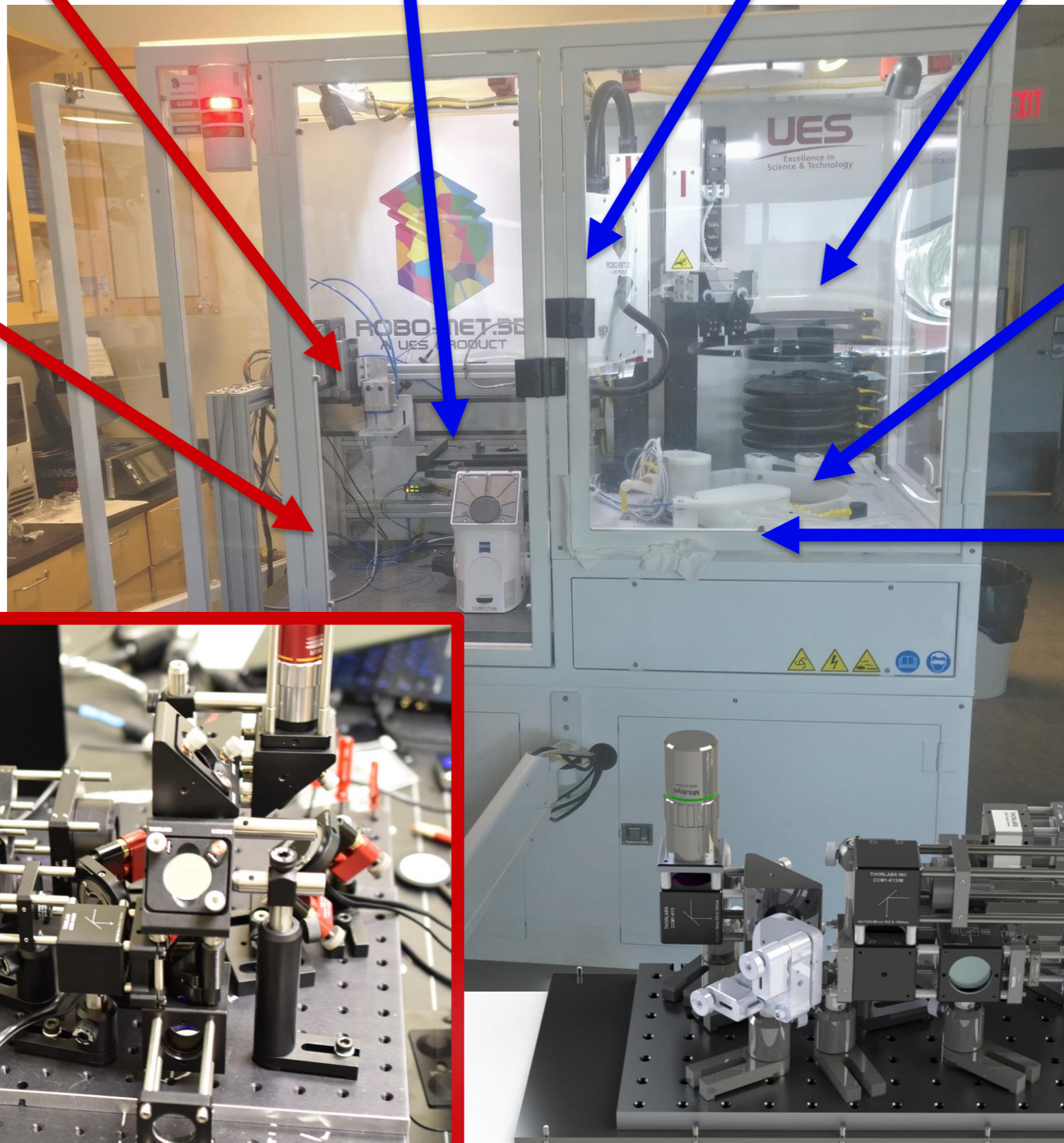
Robot 1

Auto Platten
Changer

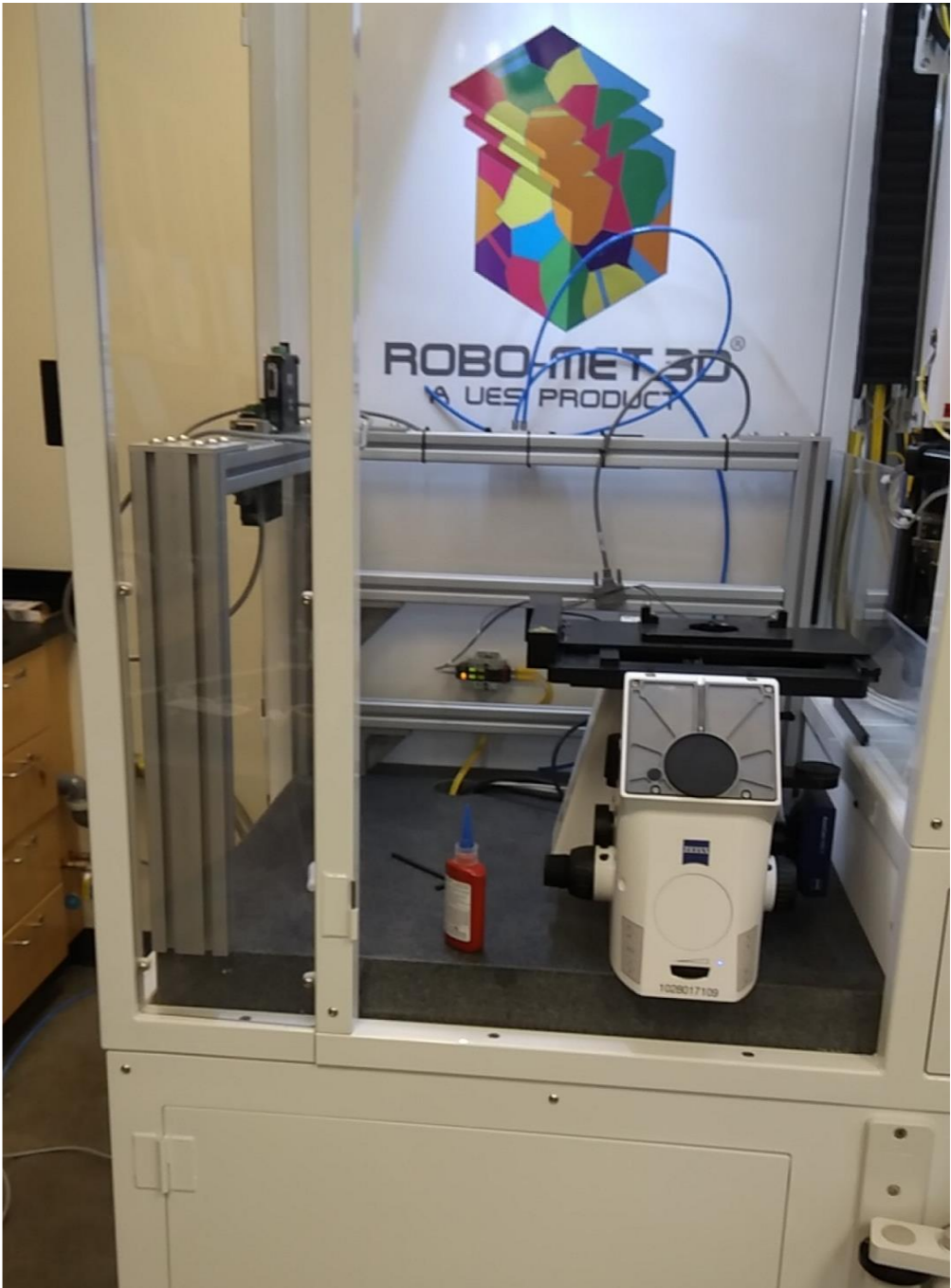
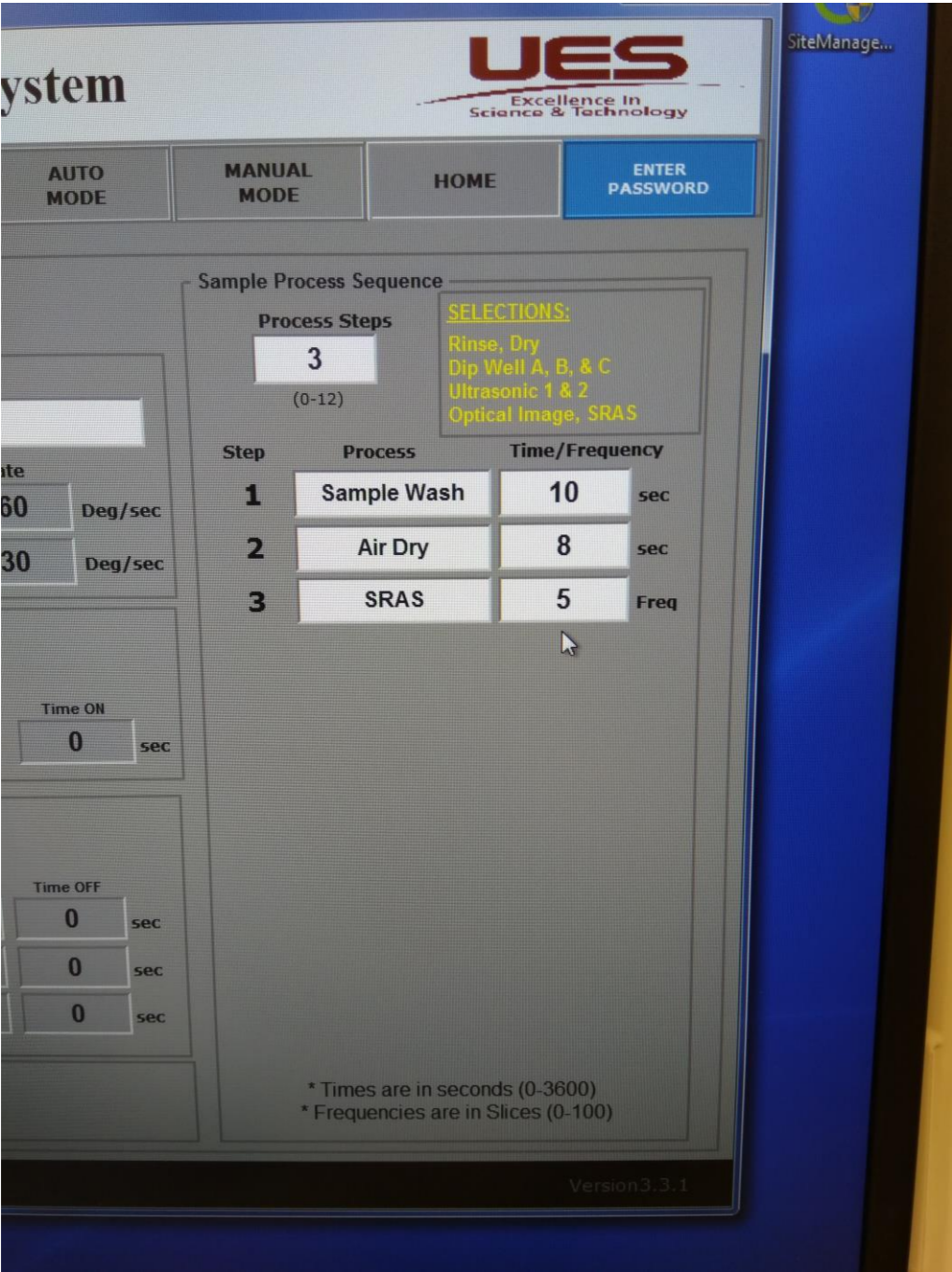
SRAS

Polishing
Wheel

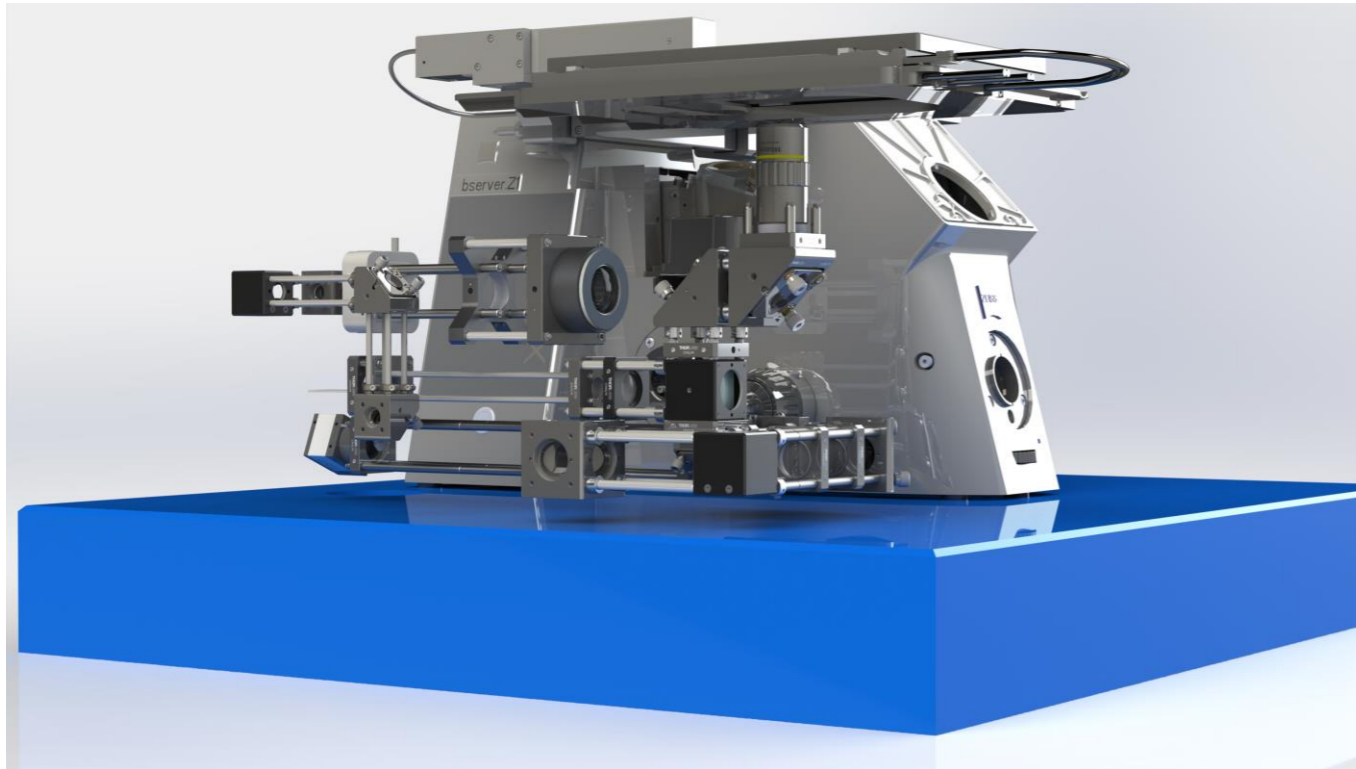
Etching
Station



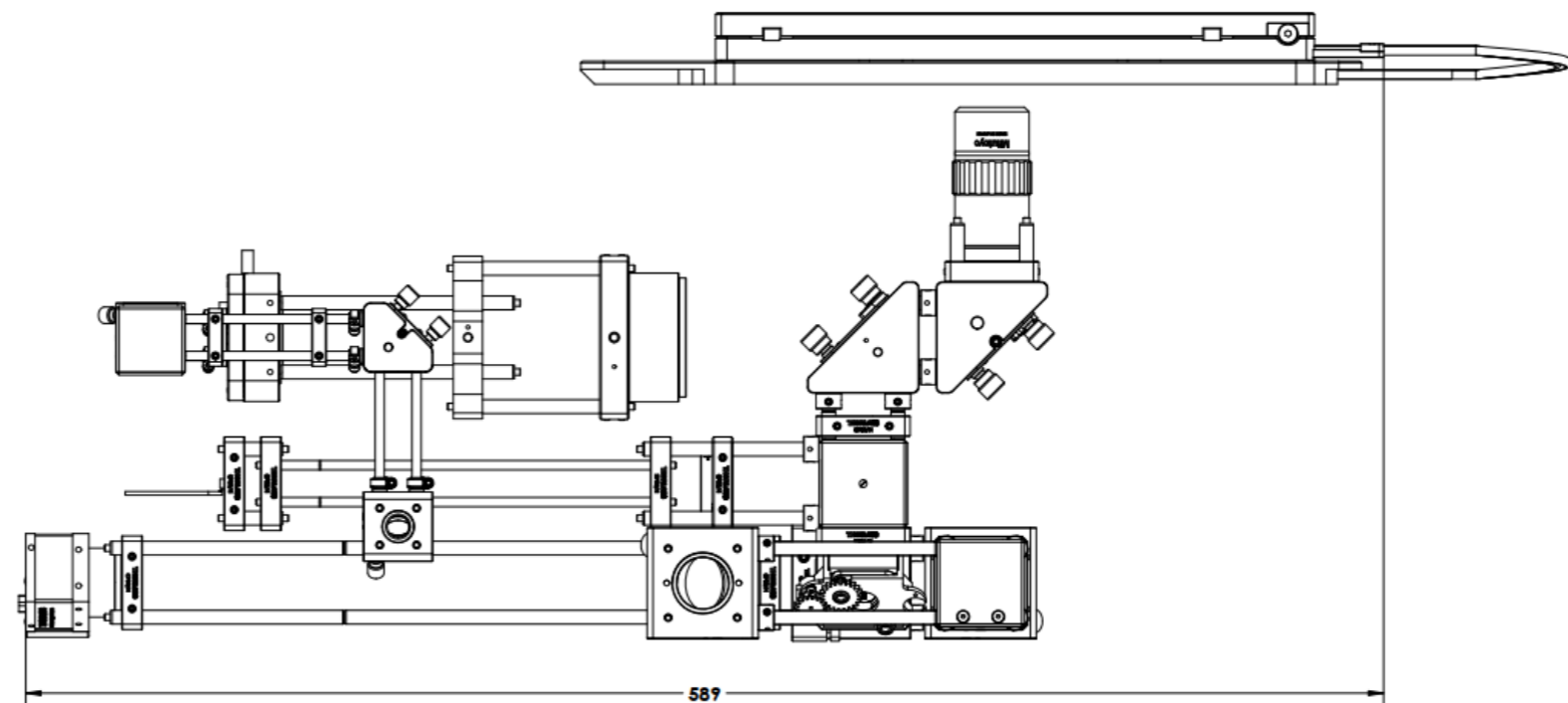
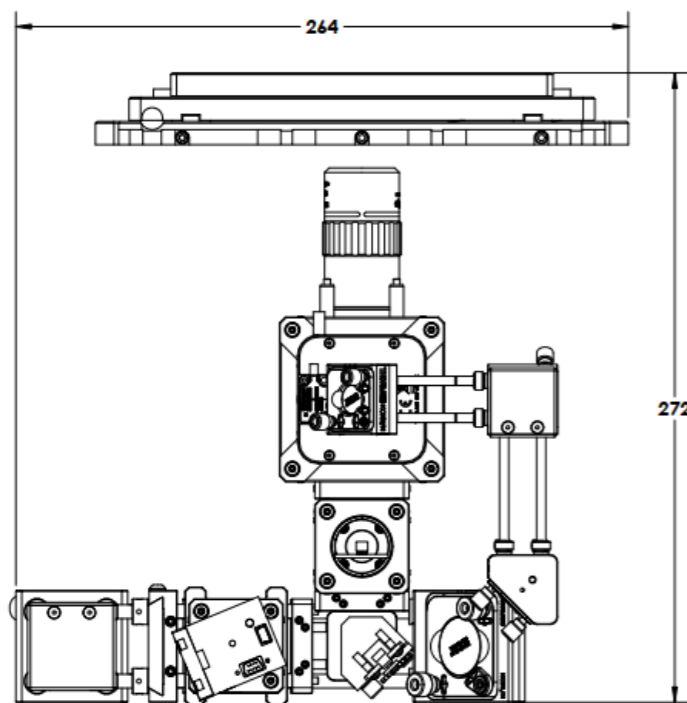
Modified RoboMet.3D PLC & Custom Transfer System



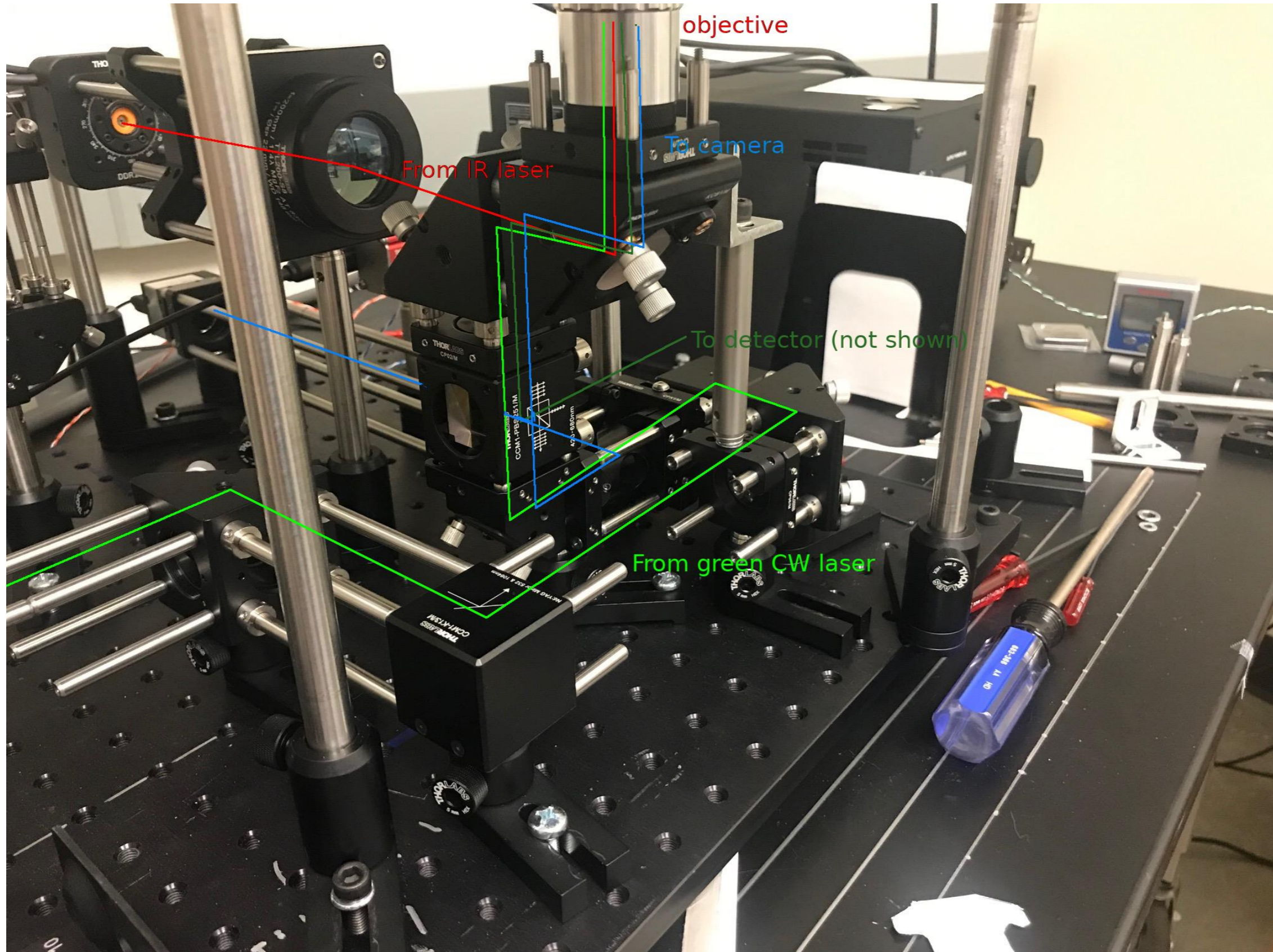
Engineering a new system

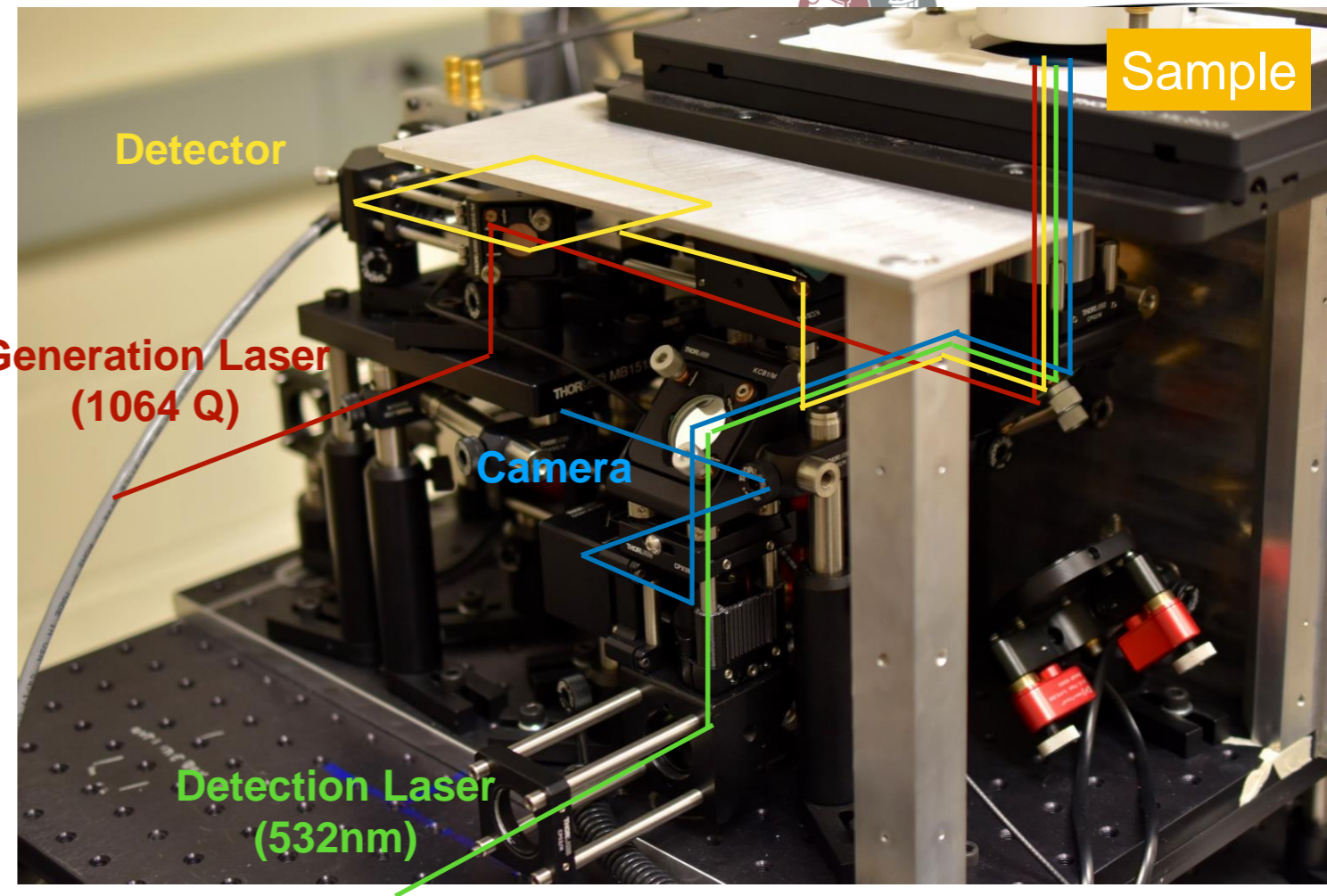
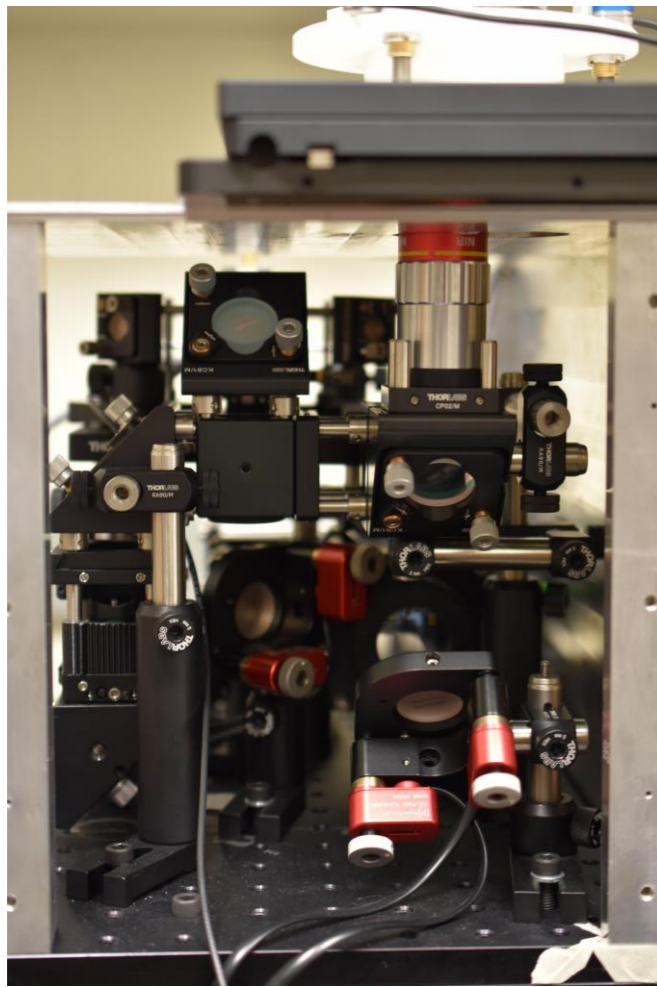


- Must wrap a 2D system to a 3D package
- Tight space constraint
- Safety (Class 1 Required)!
- Critical detector components no longer exist
- Bandwidth (150-500 MB/s if we collected everything!)



First Original 3D Beam Path



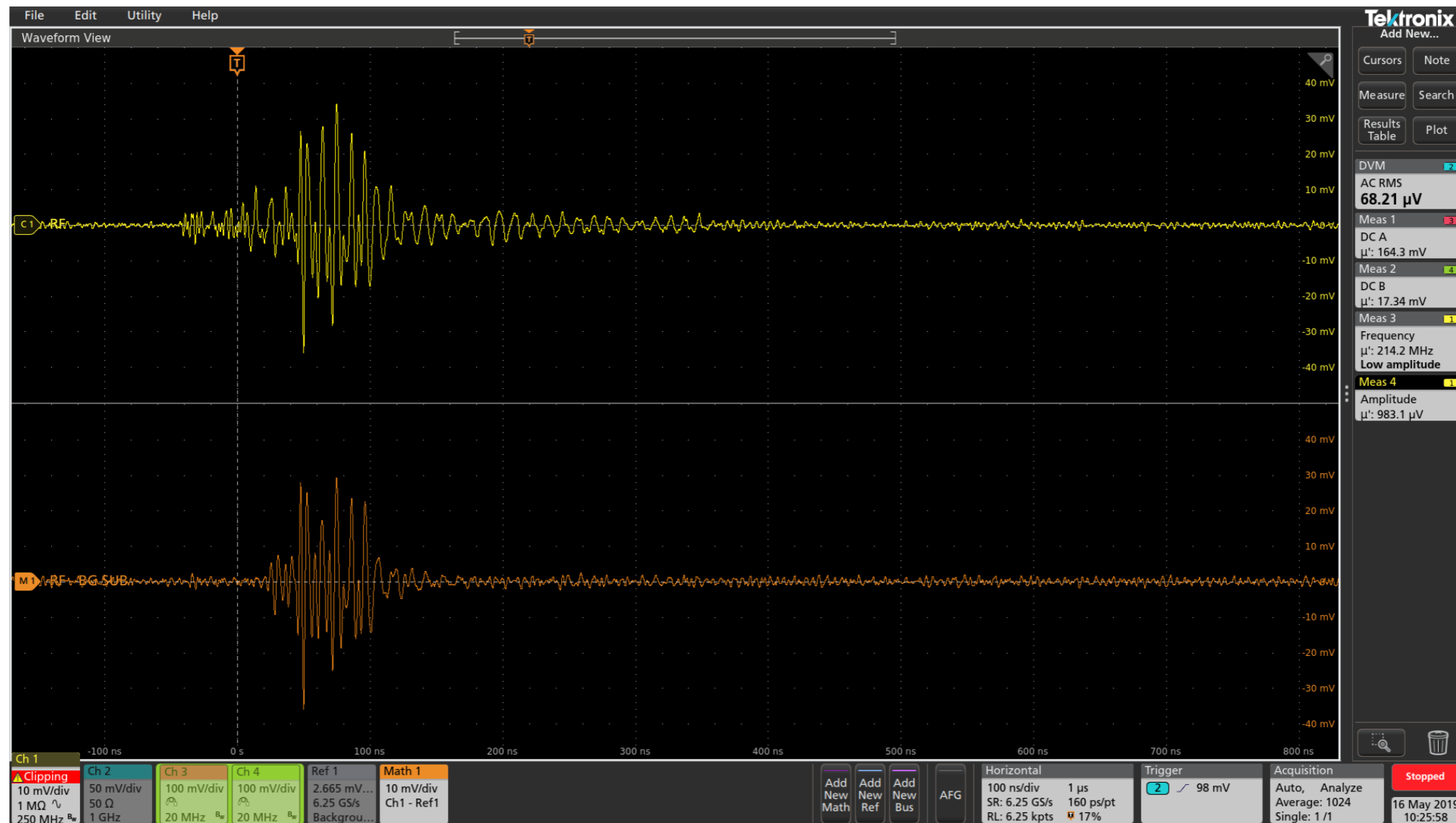


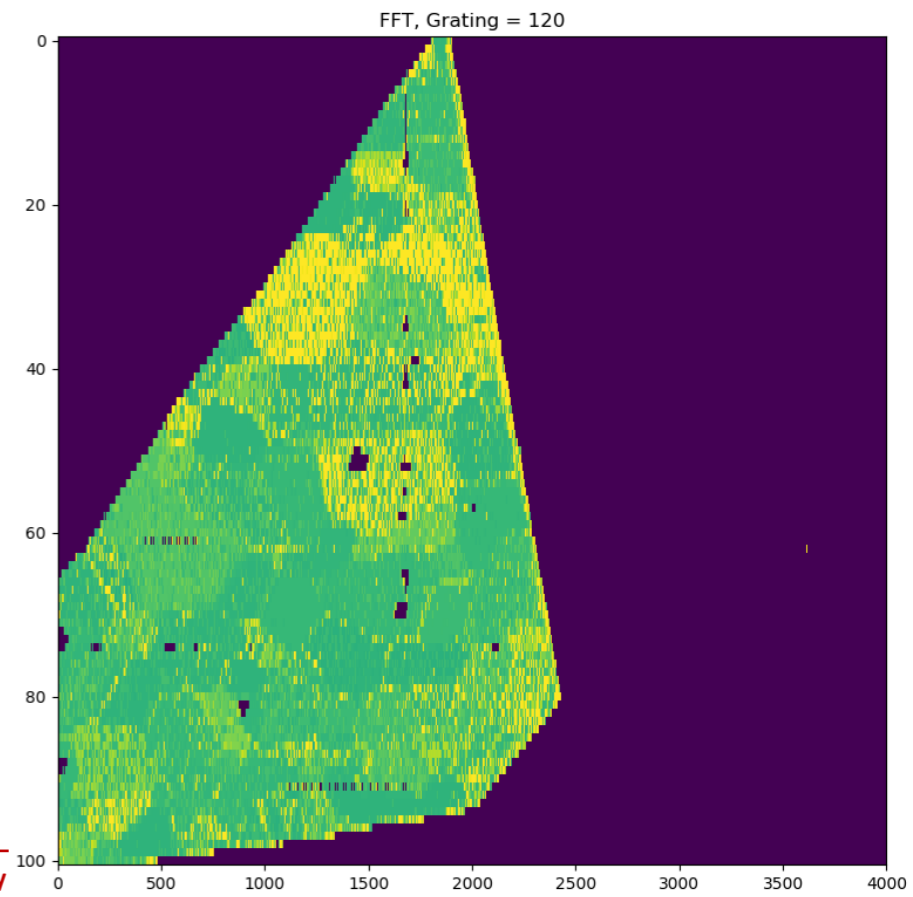
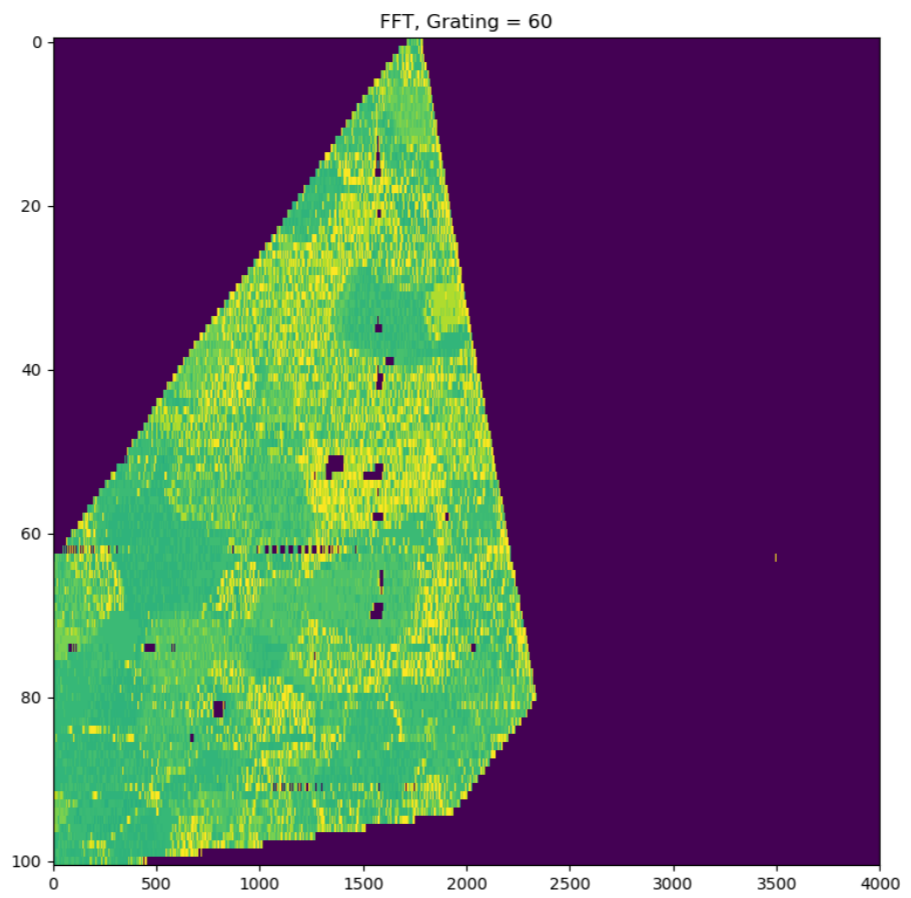
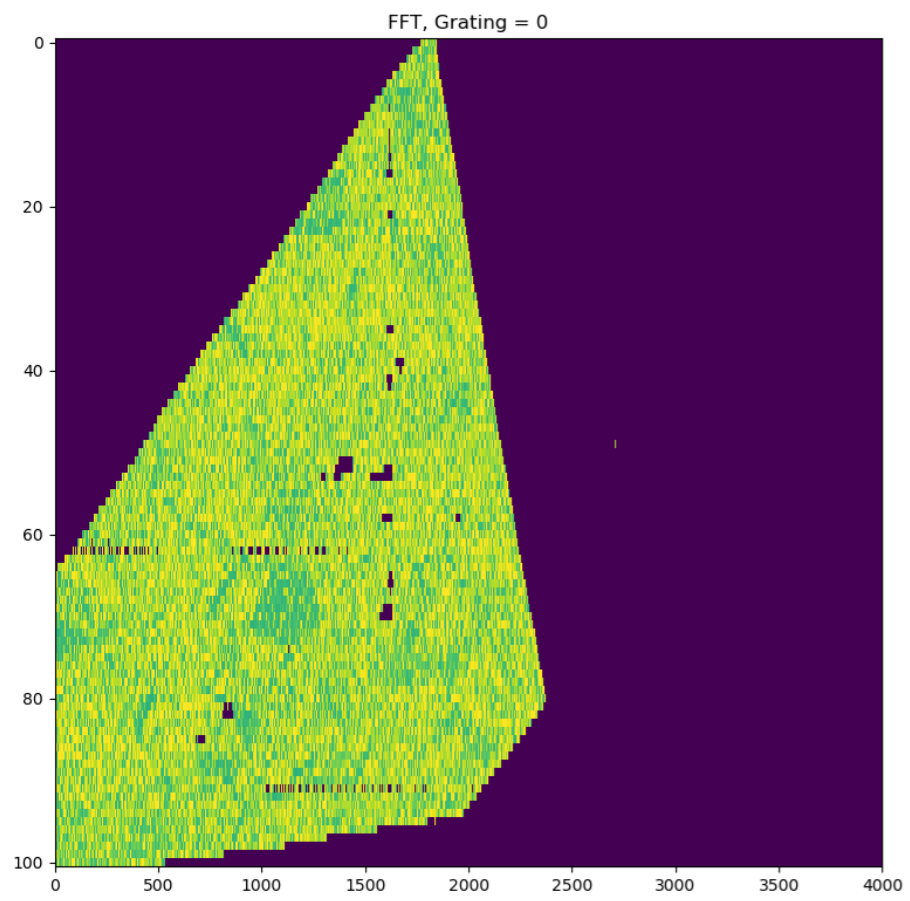
Subsystem		
Generation Laser	Type	Q-switched
	Wavelength	1064 nm
	Pulse Energy	>50 uJ
	Pulse Duration	<900 fs
	Frequency	20-100 kHz (continuous pulse)
Detection Laser	Type	CW
	Wavelength	532 nm
	Mode	TEM ₀₀
	Power	0-500 mW ~200 mW

Subsystem		
Stage	Speed	250 mm/s
	Acceleration	2500 mm ² /s
	Backlash	None
	Accuracy	<0.25 um
	Incremental Movement	<100 nm
Detector	Type	Balanced Split PD
	Generation	New (1st since ~2011)
	Frequency	< 500 MHz
	Spatial Resolution	~ 25 um

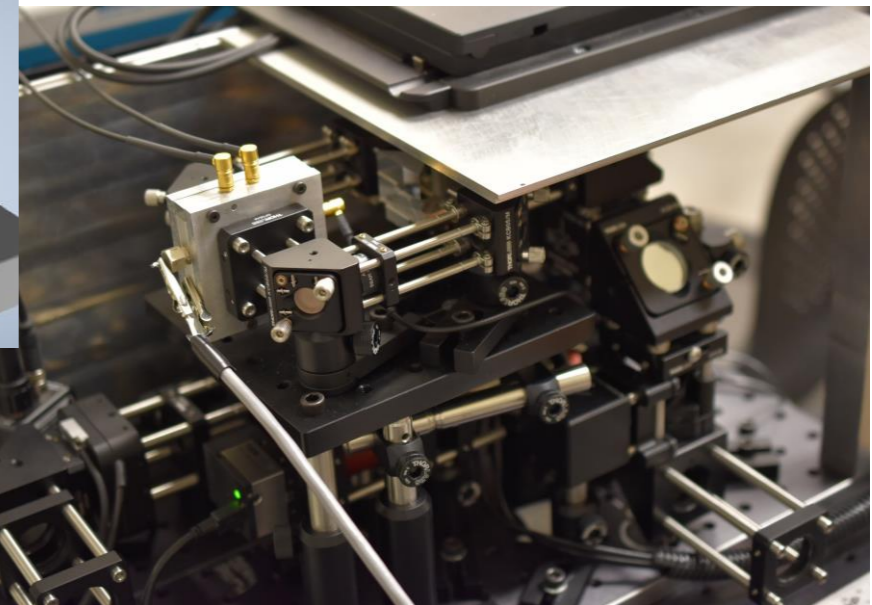
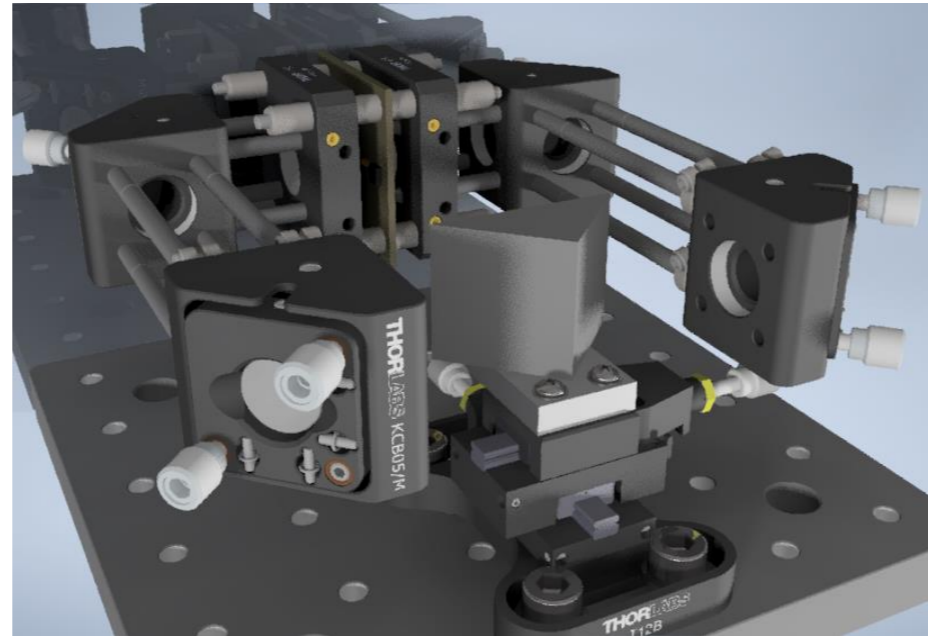
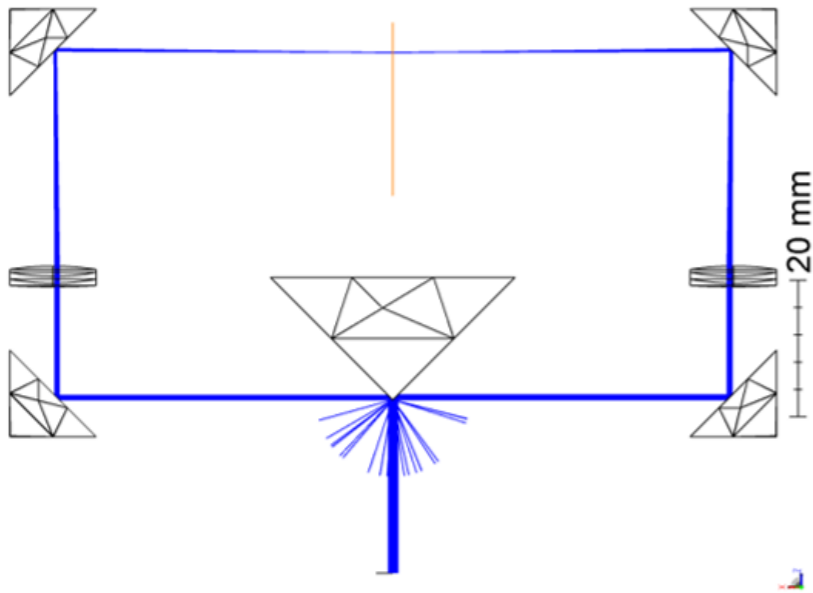
Detector (Nottingham "Slow")

First signals (June)

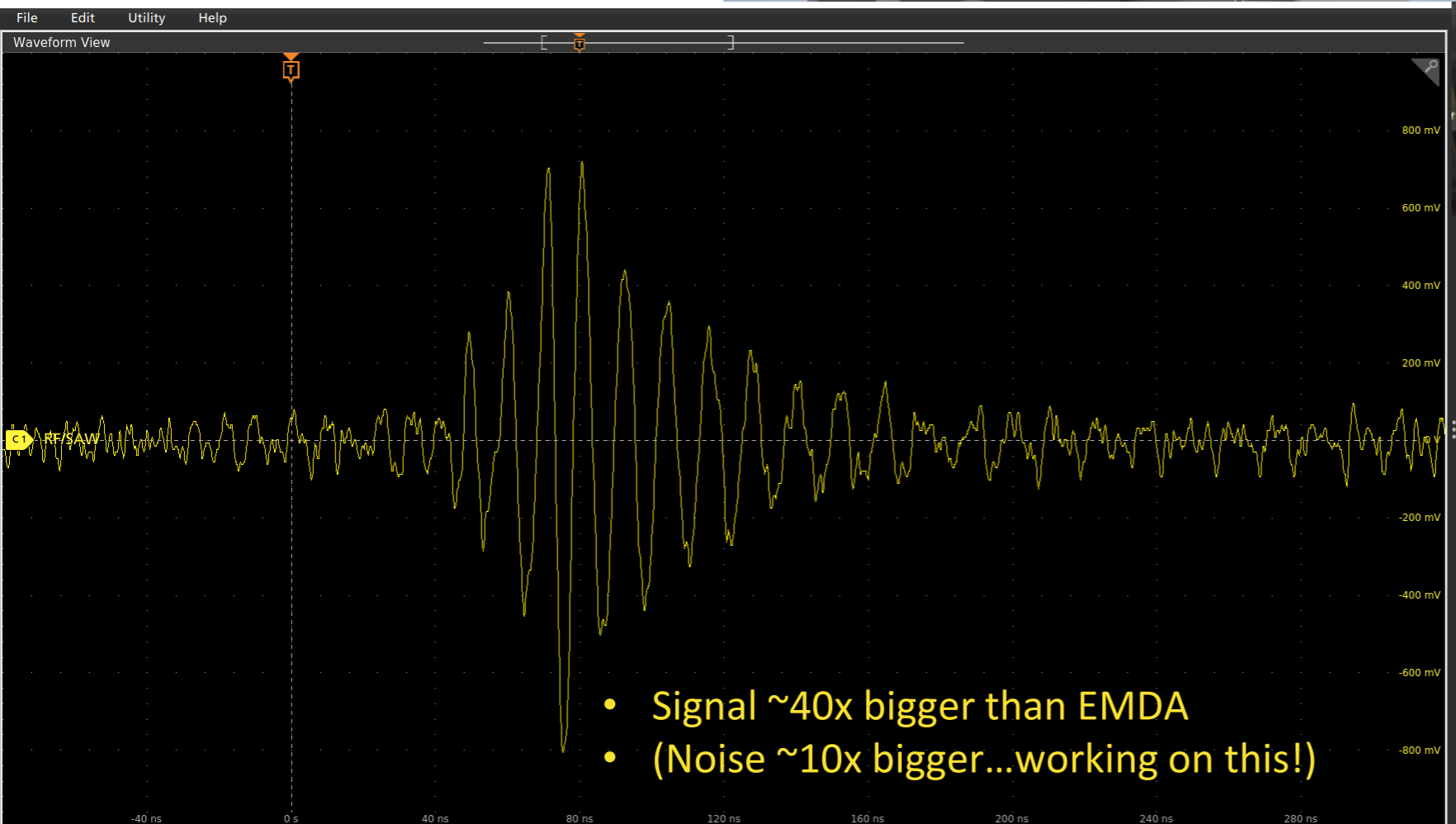




Detector (Gen 2 - new design)

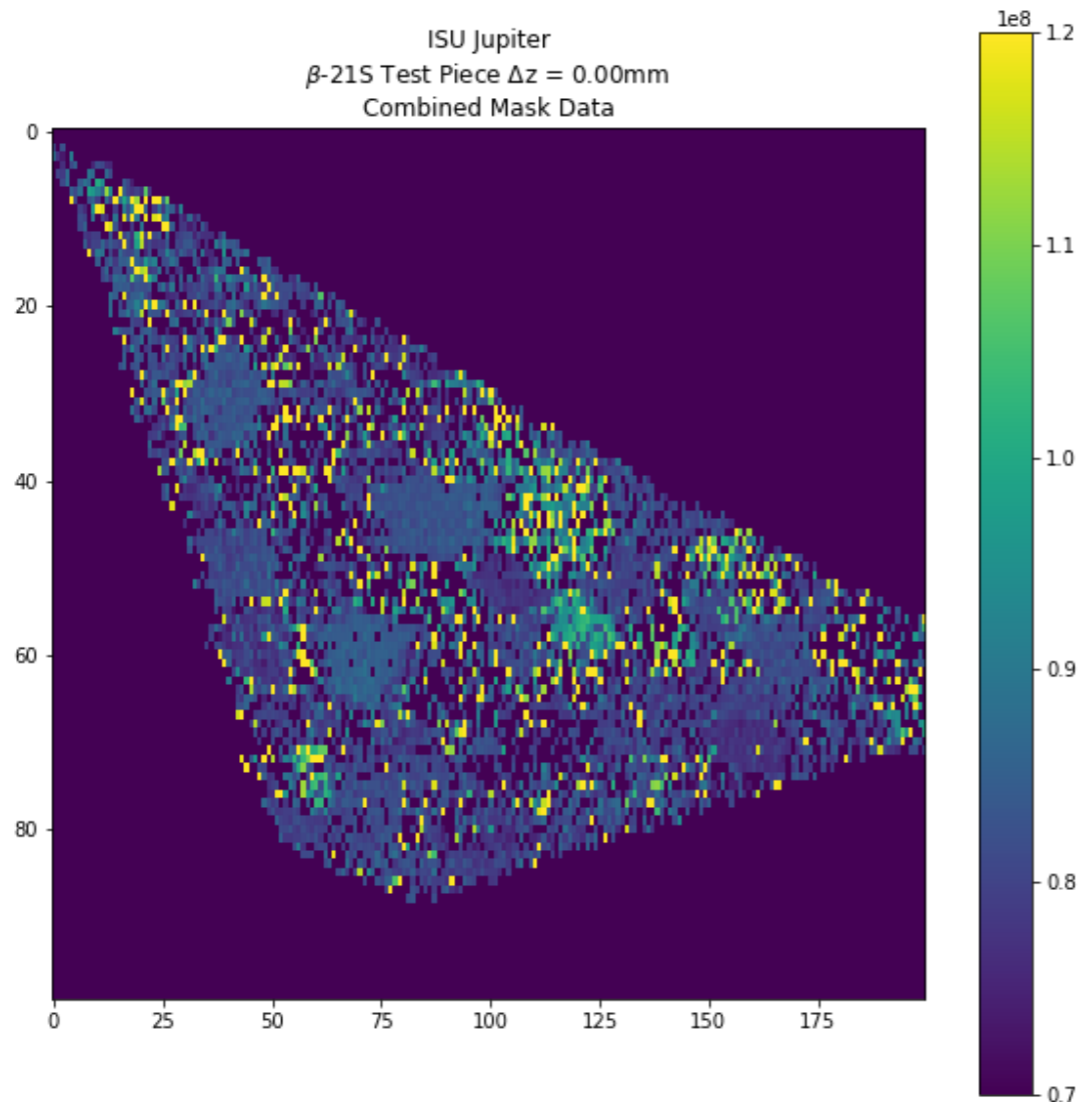


November

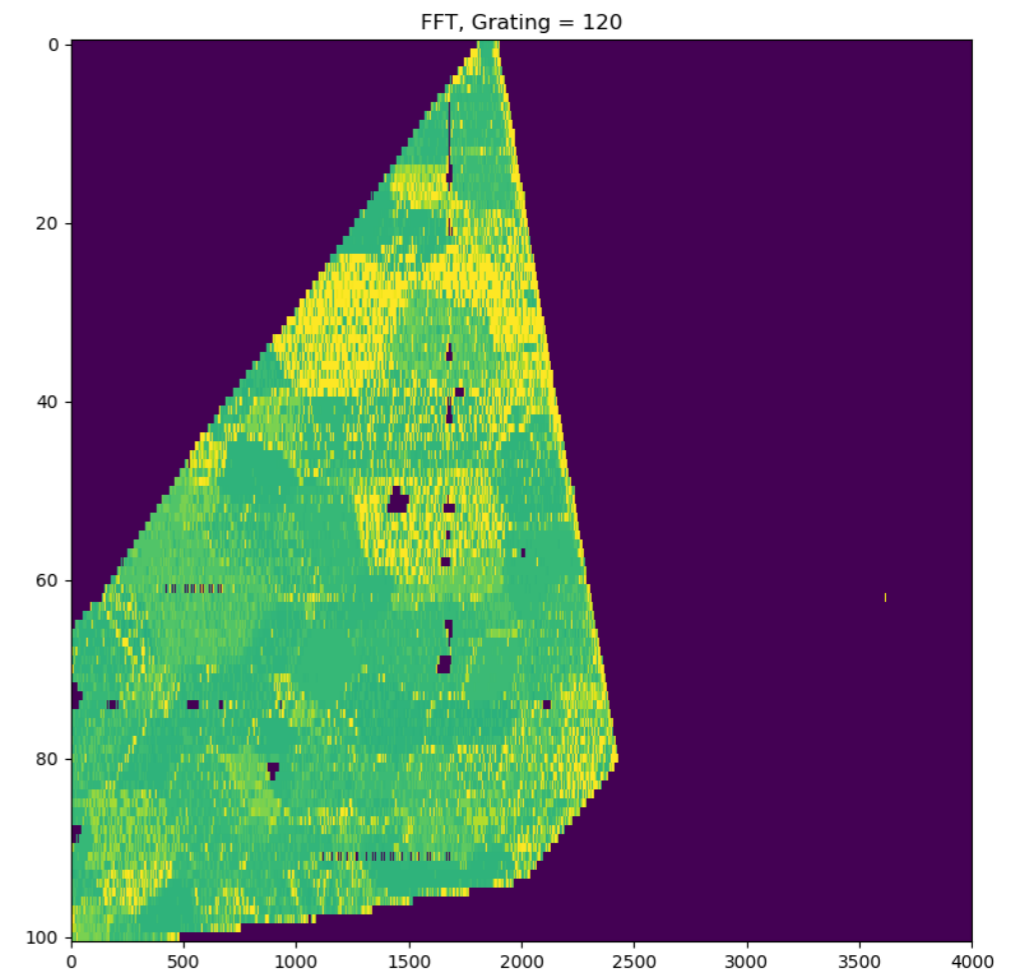


Present State-of-the-Art

- ISU Alpha system running, efforts being spent on improving resolution, data acquisition and data transfer rates
- Current RAW data is $\sim 15 \text{ MB/mm}^2$
- Potential to move away from oscilloscope storage for data



1st scan acquired



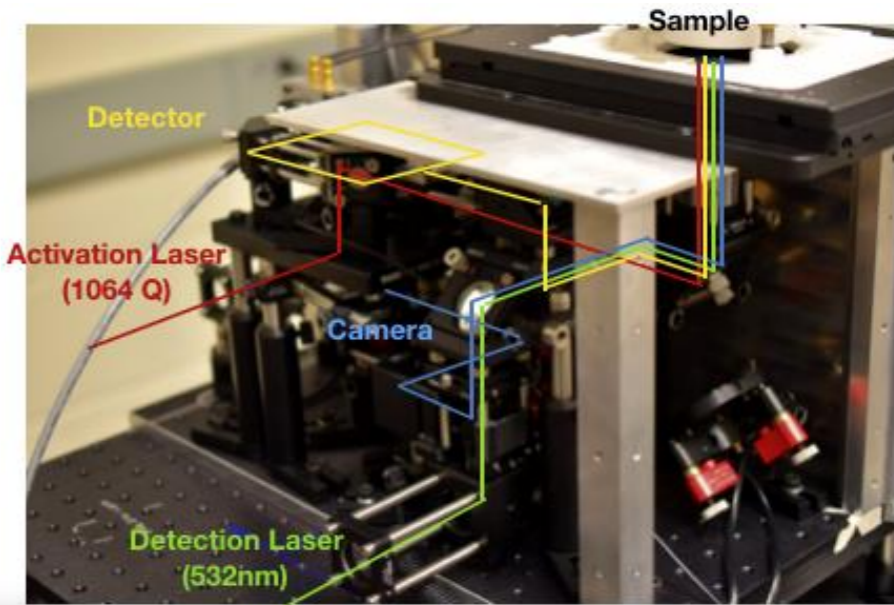
latest scan

What is left...in the short term

Left to resolve:

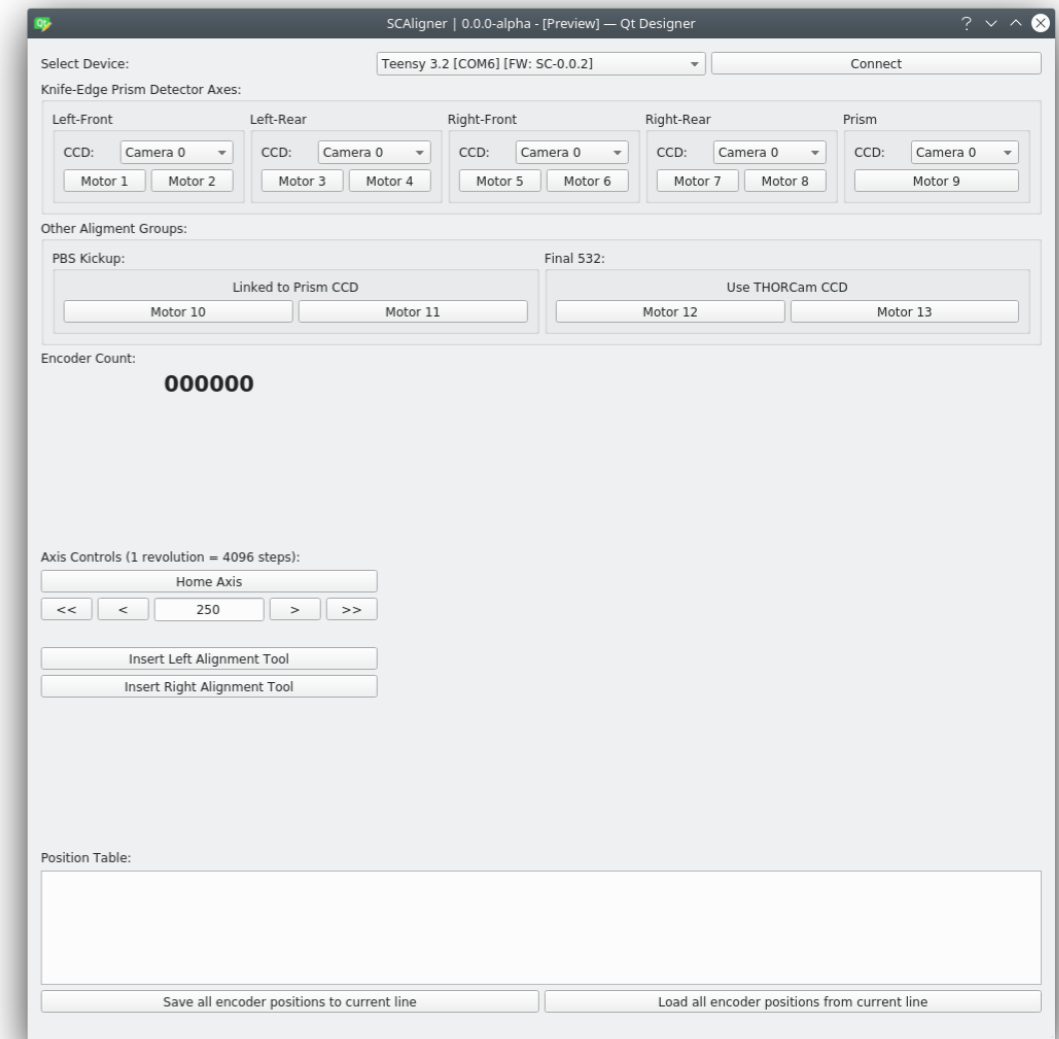
1. Taking hands out of the system
 - Finish up work on detector alignment firmware.
 - Link firmware to PC control application

2. Make the system “Class 1” laser safe
 - Install interlock control system.
 - Verify behavior during fault conditions.

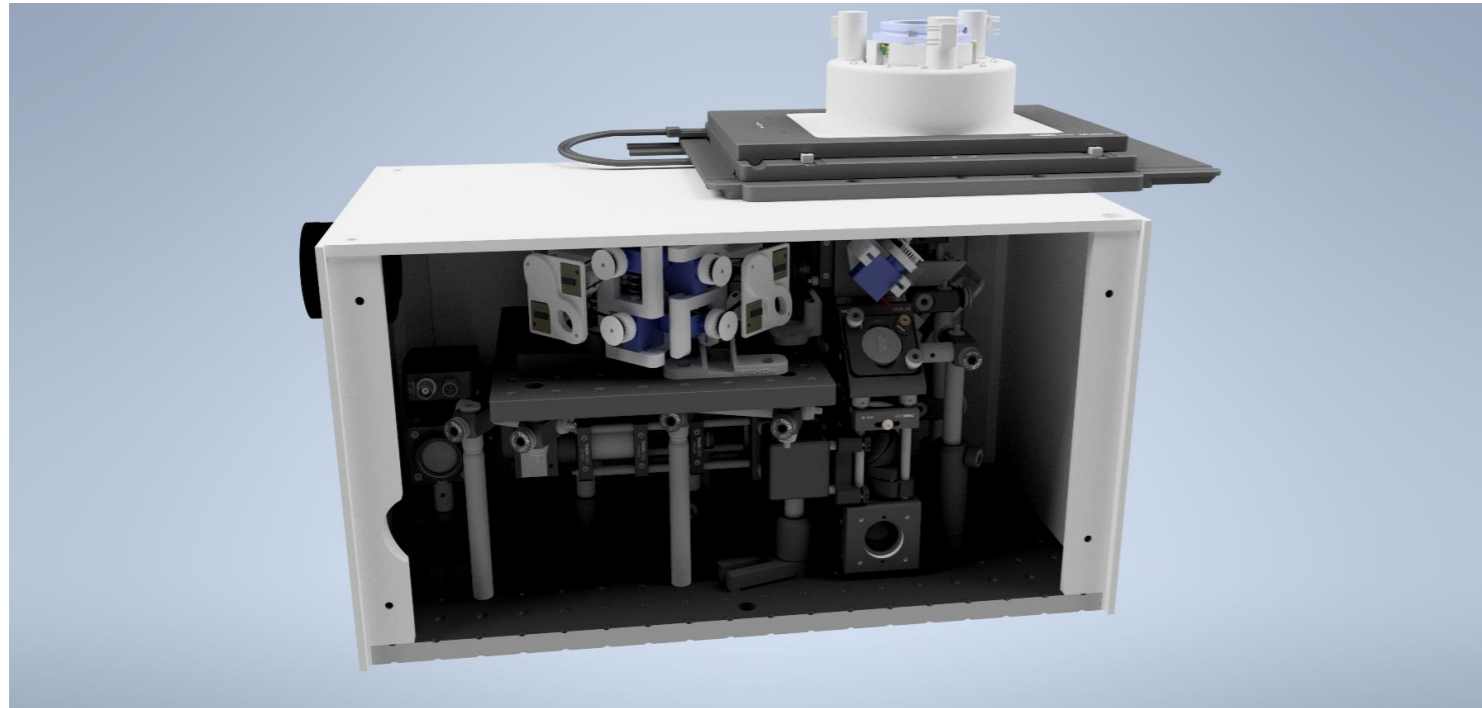


Future:

- Transition to fiber coupled lasers
- Direct collection via capture card/FPGA

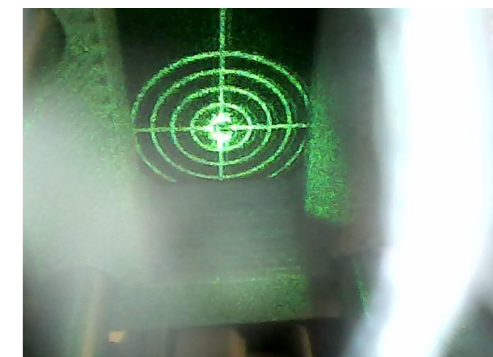
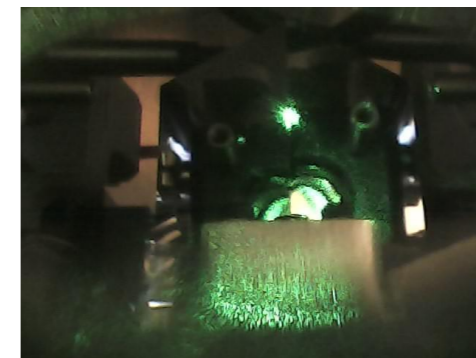
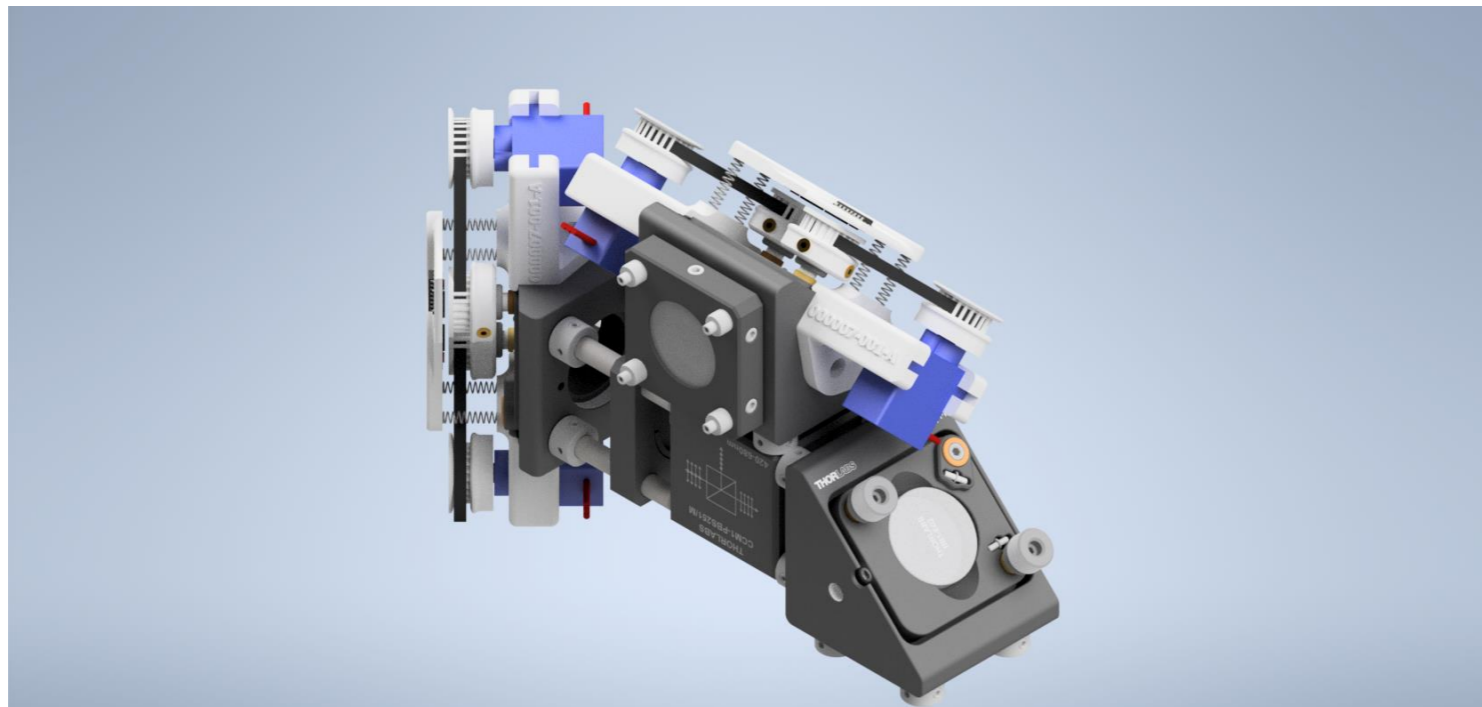


Remotely Operable

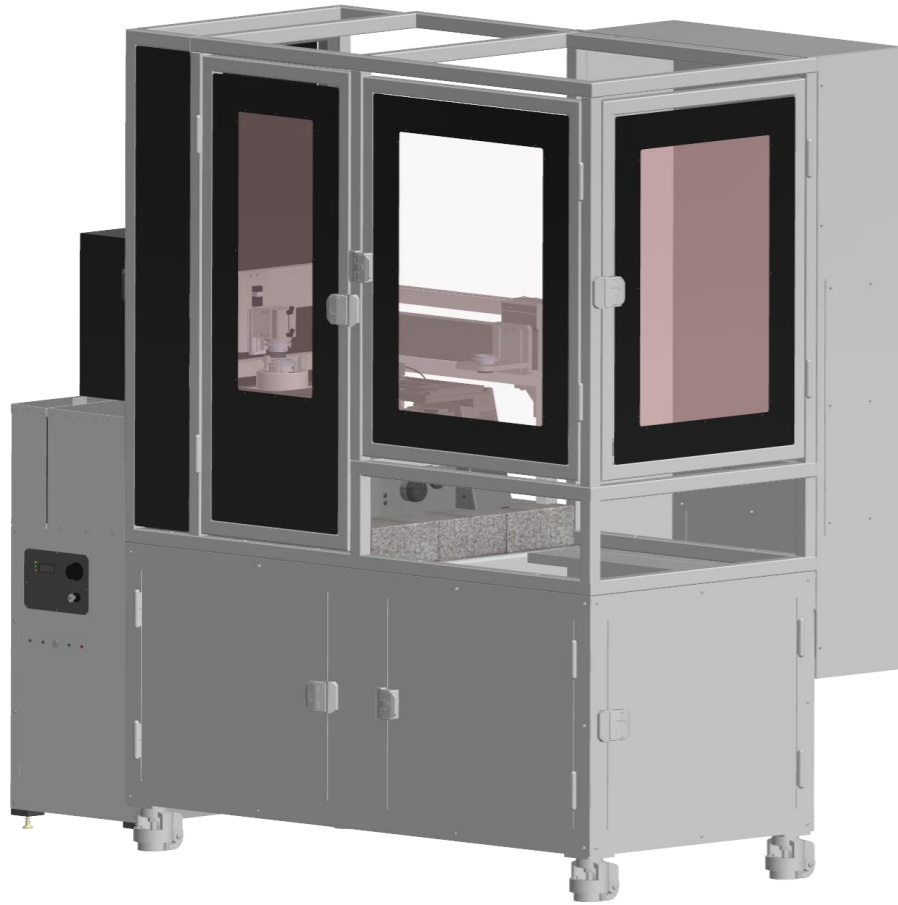


Kinematic Requirements:

- **Must be stable in power-off configuration**
- **Relatively fast rotation required.**
- **Compact physical package with relatively high torque.**



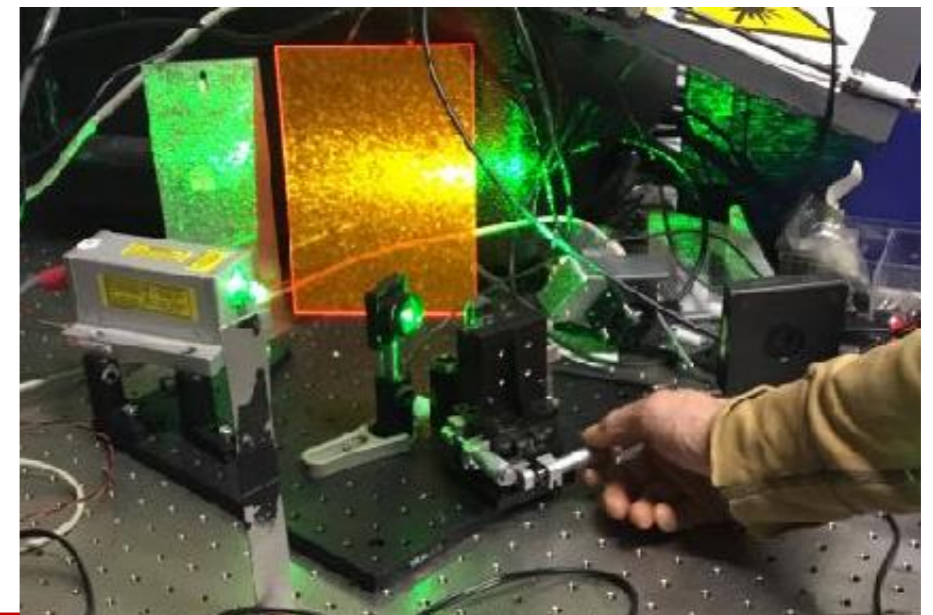
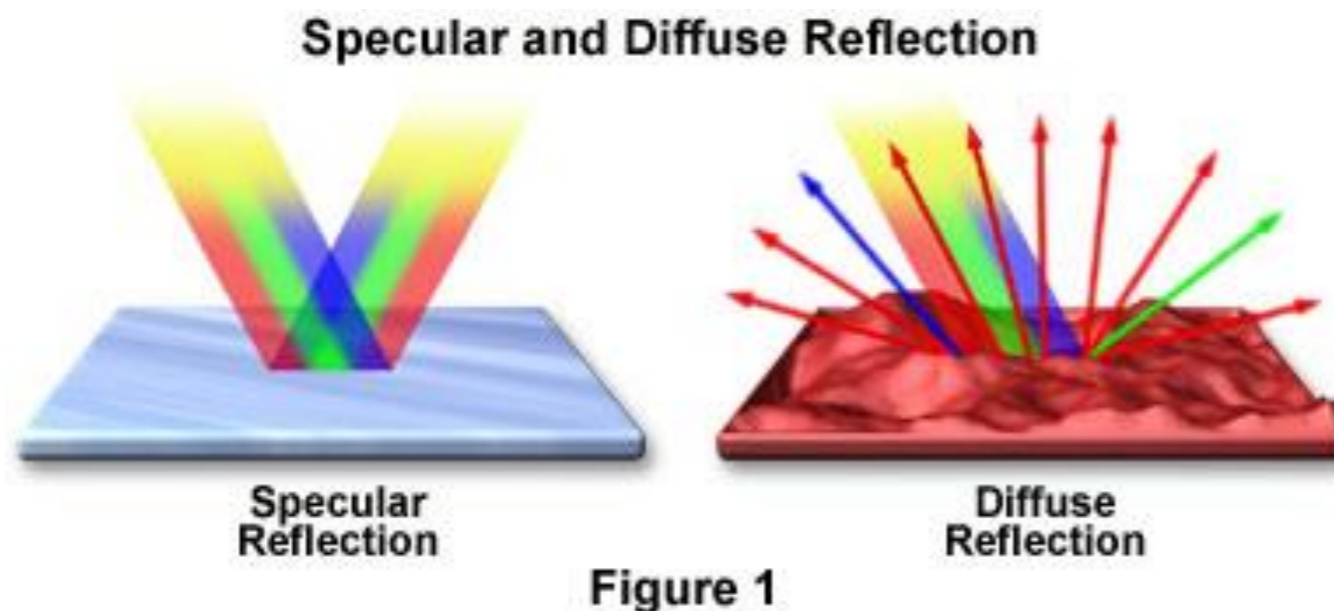
"Class 1"

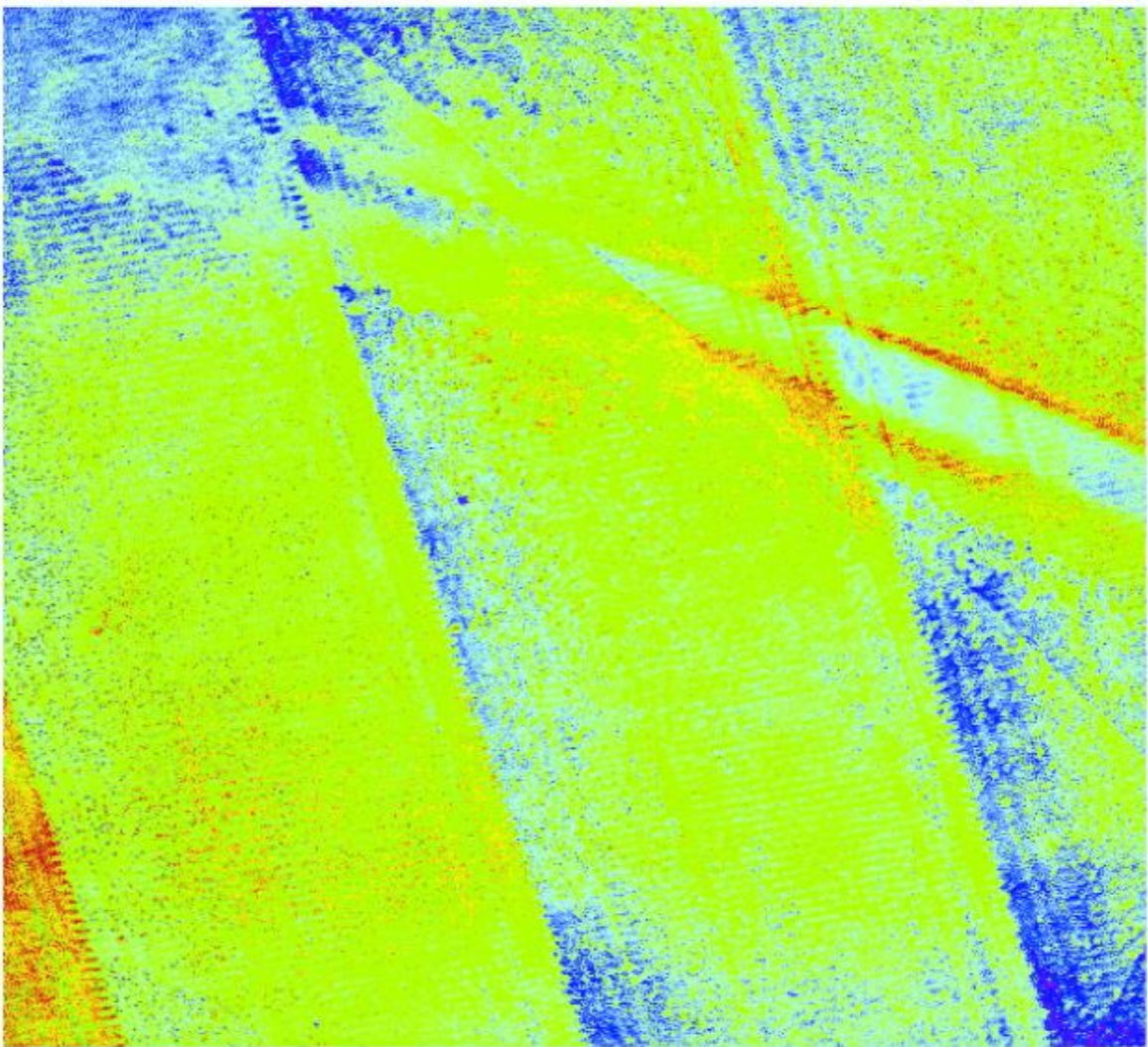
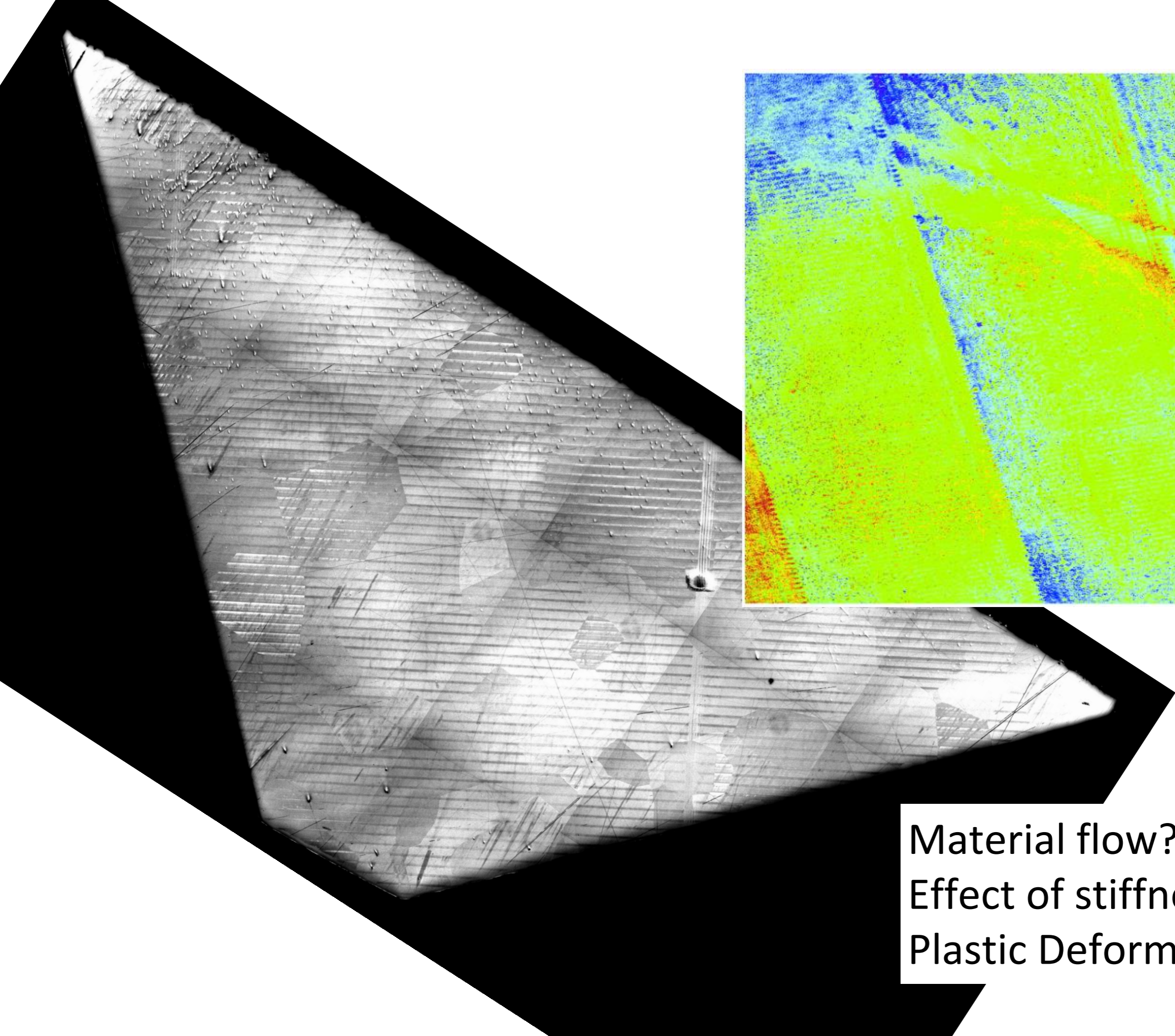


What is left...in the long term

Future possibilities

1. Rough surfaces - possibly even in the “as built” condition
2. Non planar (i.e., curved) surfaces
3. Non linear analysis paths (i.e., for MSA of electronic devices)
4. Improved resolution (a “quantum leap” to 1 μ m resolution?)
5. Time resolved experiments
6. Real-time determination (requires both a Gen-3 detector, laser upgrades, and clever databased approaches)





Material flow?
Effect of stiffness?
Plastic Deformation?

Bottom Line: Possibilities and Limitations

Possibilities:

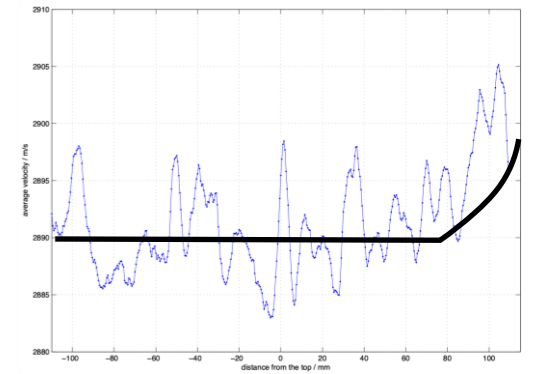
- Rapid orientation microscopy at large length scales (dm^2) and in 3D (cm^2)
- Time resolved experiments of dynamics
- Measure/map any single variable that affects C_{ij} (including composition)

Probabilities:

- Orientation microscopy on rough surfaces (demonstrated in UK)
- Orientation microscopy on curved surfaces (theoretically possible)

Limitations:

- No split photo diode with sufficient bandwidth (resolved for now)
- Resolution (but a higher resolution should be possible)
- Data and bandwidth is a challenge (but solvable)
- Manufacturing infrastructure (resolving...but it takes time)
- Sparsity in scientists
- Multiple variables will convolve the signal

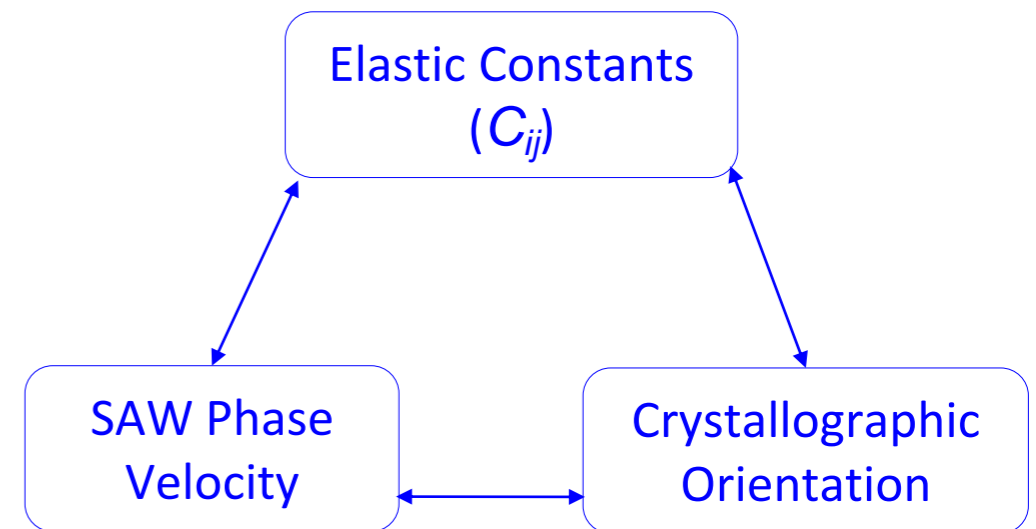


Post-process workflow

The forward model:

- Math says that if you have any two adjacent points on the triangle, you ***should*** be able to get the third.
- Solving for orientation as a function of phase velocity and C_{ij} is unstable at best and quixotic at worst.
- Brute Force the solution using a “forward model”. Then match results.

Elastic constants, SAW Phase Velocity, and Crystallographic Orientation are interrelated.

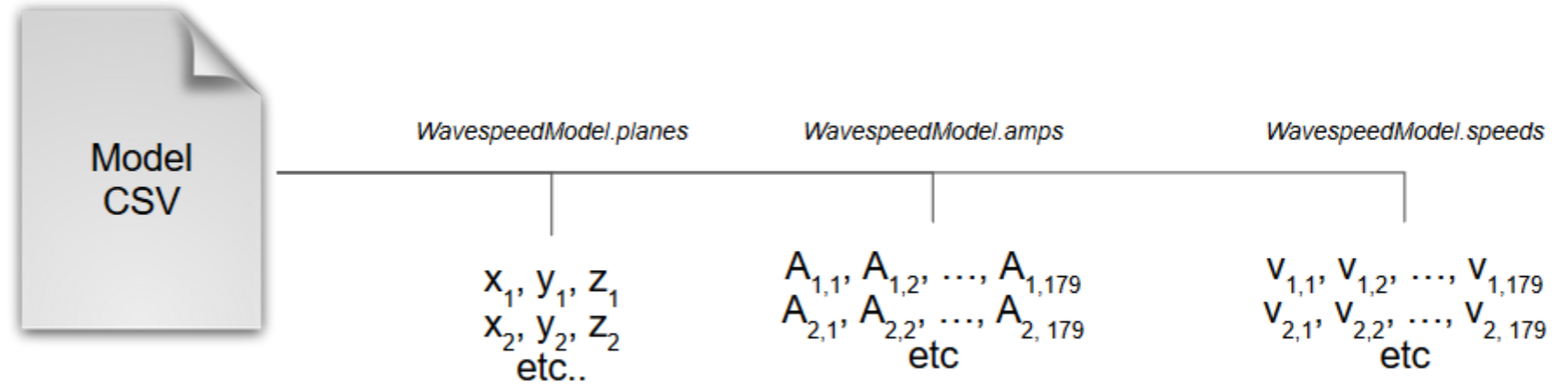


```

C:\Users\tka\source\repos\SRASForwardModel\SRASForwardModel\bin\Debug\SRASForwardModel.exe
T1A
C11=163.6, C12=92.3, C13=67.92, C14=0
C21=92.3, C22=163.6, C23=67.92, C24=0
C31=67.92, C32=67.92, C33=185.2, C34=0
C41=0, C12=0, C43=0, C44=47.05
Plane: [0 0 0.1, 0 / 970].
deg: 0
deg: 1
deg: 2
deg: 3
deg: 4
deg: 5
deg: 6
deg: 7
deg: 8
  
```

Post-process workflow

Now what?



Split the model CSV into a series of row-linked object properties for ease of lookup.

For every row:

For every pixel:

Extract experimentally acquired speeds at this pixel

Interpolate speeds between 0-180 and weight accordingly

For every plane in the model:

For 1* shifts in the model:

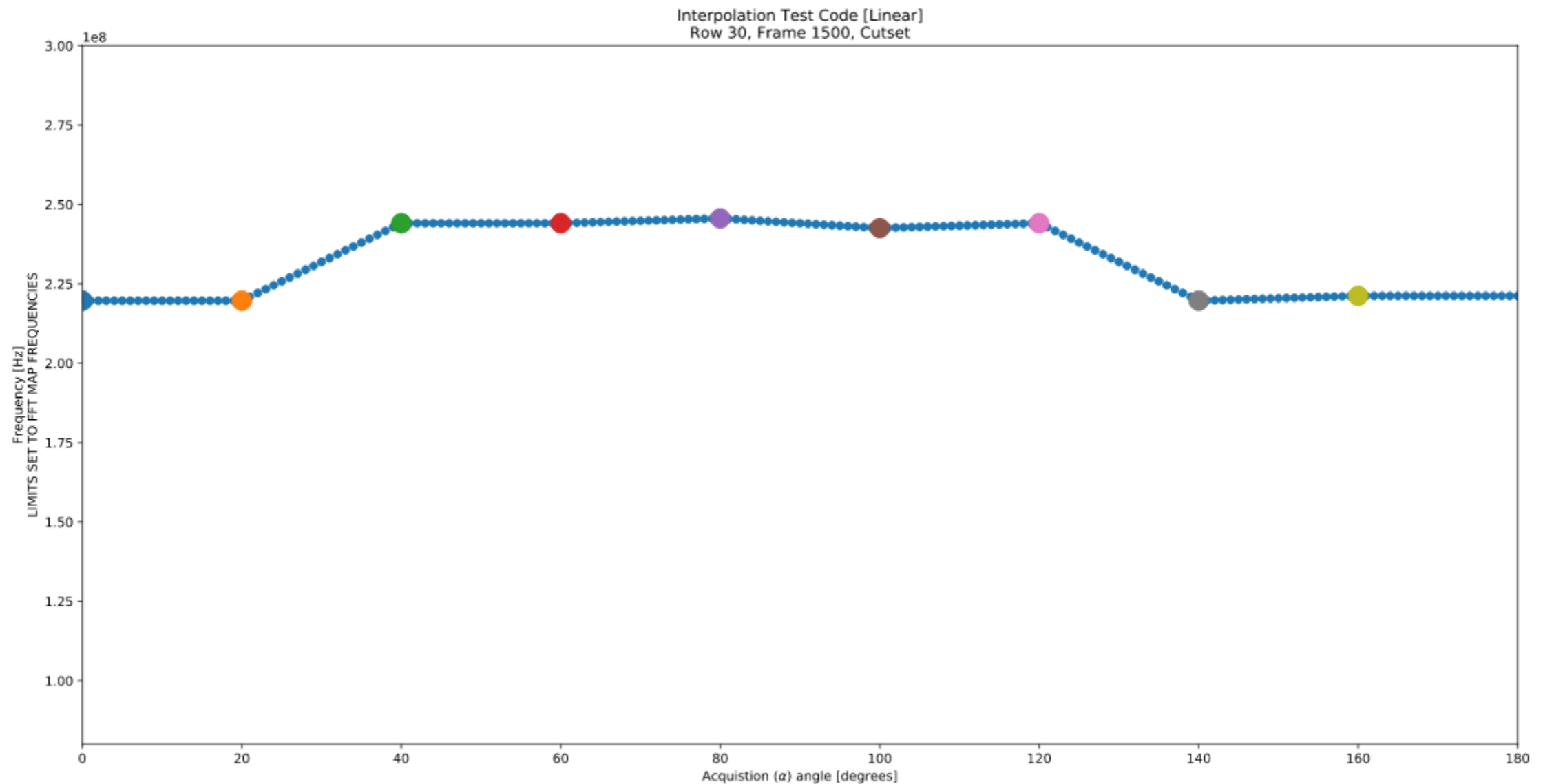
Compare model v. experimental, assign fitness score

Choose highest score out of all planes + rotations and assign as plane normal.

Delta between model speed and required rotation is Phi

Repeat 80,000 times or so.

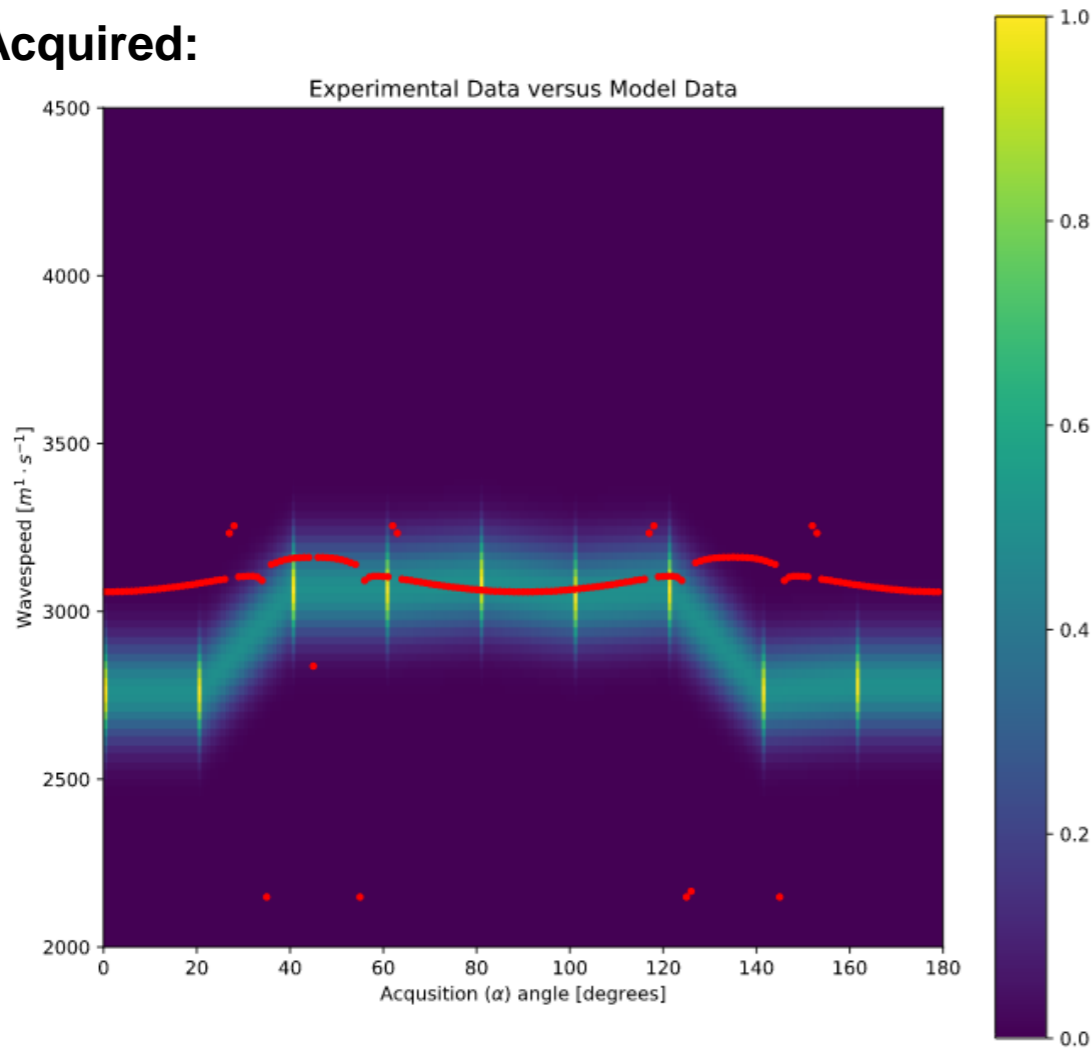
Post-process workflow



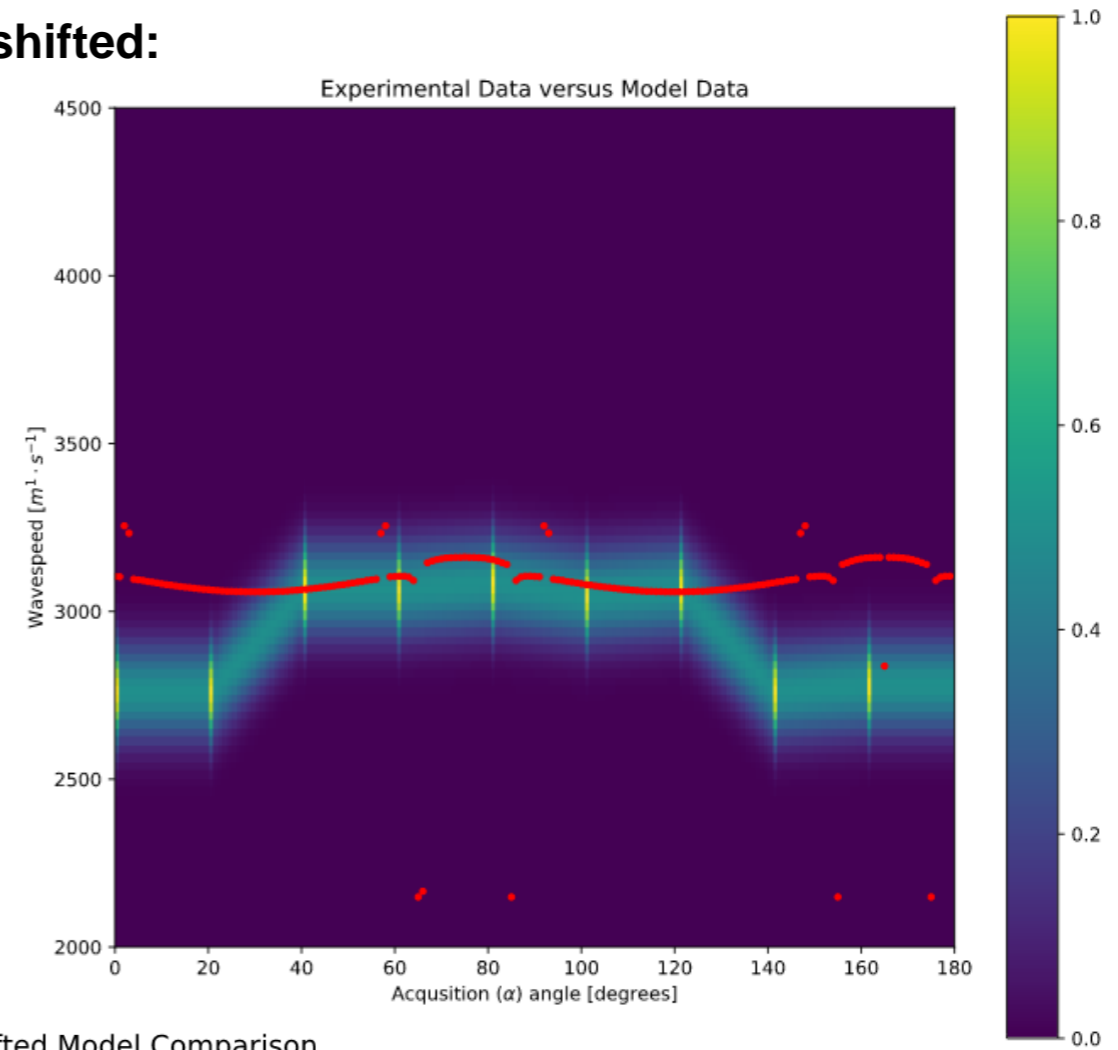
Example of interpolated experimental frequency data.
 Small blue dots – Interpolated linear piecewise
 Large multicolored dots – Data from SRAS scans for pixel

Post-process workflow

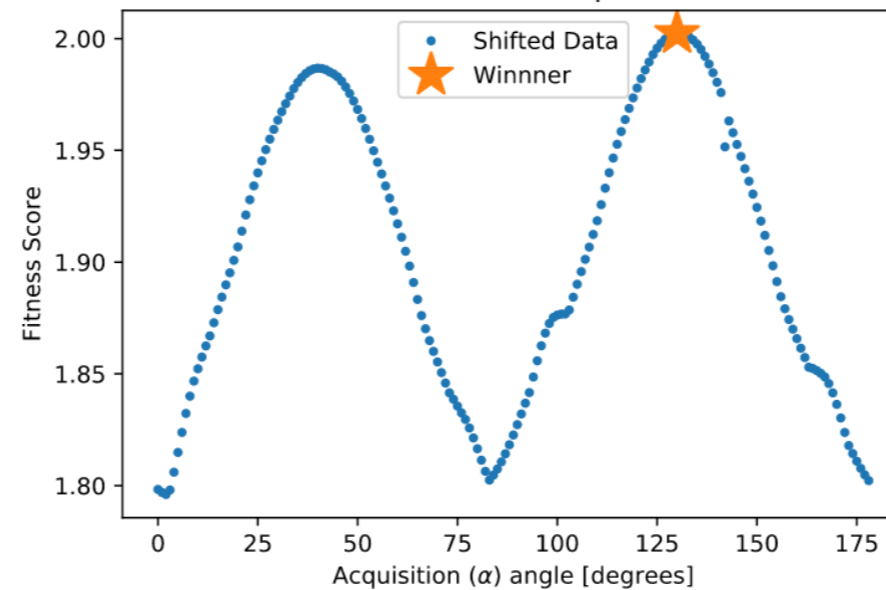
As Acquired:



α-shifted:



Shifted Model Comparison



Jun-Oct Update

Post-Processing Workflow Progress

- C_{ij} -specific matching algorithm has been rewritten in C for speed.
- 22x speedup as compared to pure-python implementation. (This is using NumPy as well)
- Tool is being developed to auto-generate high-speed portion of code for a given C_{ij} solution set.

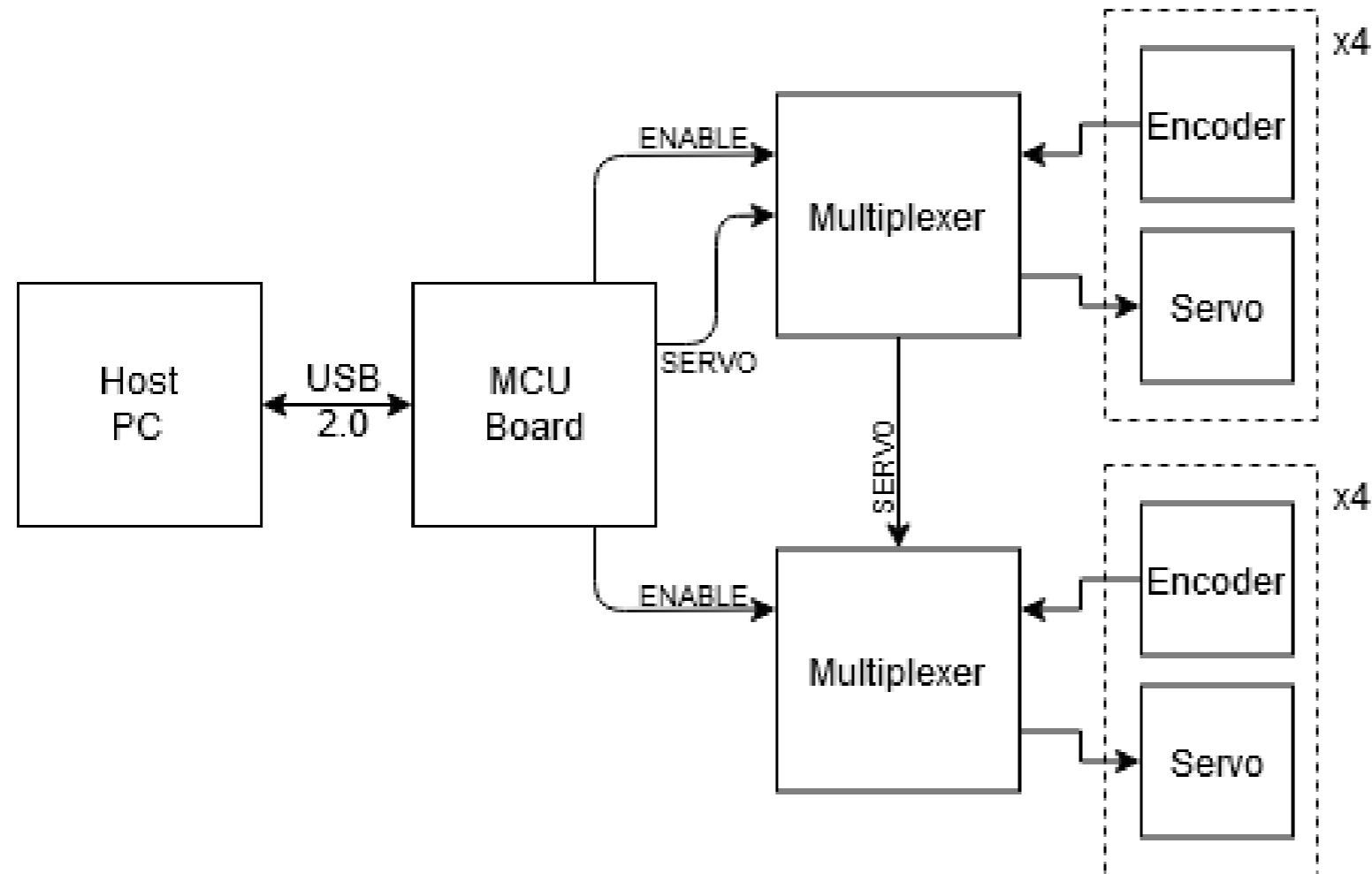
Detector Progress

- Electronic control system has evolved 3 generations
 - GEN1: Individual 32-bit up/down counters and always-on servo signals
 - GEN2: 4-into-1 OR-Multiplexed encoder signals. Switchable single-servo control.
 - GEN3: Individually selectable encoder signal and servo routing. Infinitely expandable through addition of SIPO (Serial-In, Parallel-Out) registers

- Positioning hardware has evolved 2 generations
 - GEN1: Homing via stall detection of servo.
 - GEN2: Low profile homing switch using modified KCB05/M mount.

Detector Progress

GEN3 Servocontroller

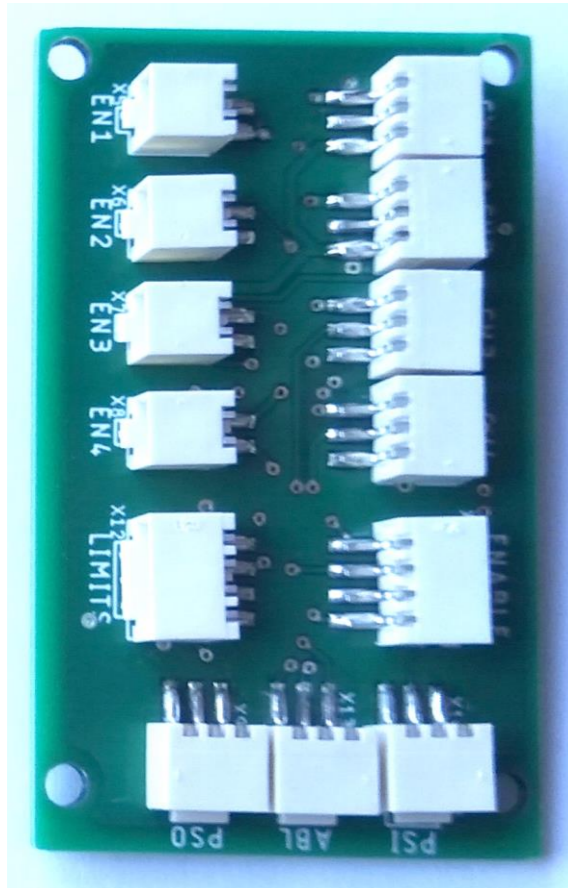


Finalized block diagram for the servocontroller hardware system.
(Only two of four multiplexer modules are shown for brevity)

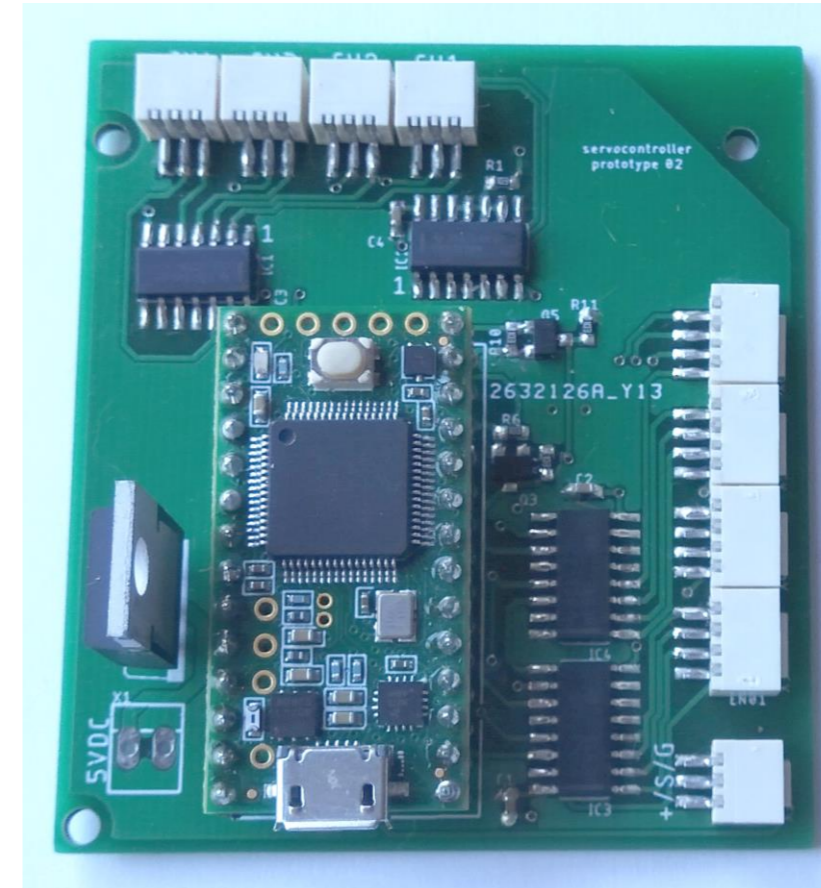
- Initial capacity:
16 continuous channels
2 range-limited channels
- Expandable as needed through addition of multiplexer modules
- Encoder precision is programmable between 128-4096 pulses/rev
- Firmware uses simple JSON-based message protocol

Detector Progress

GEN3 Servocontroller



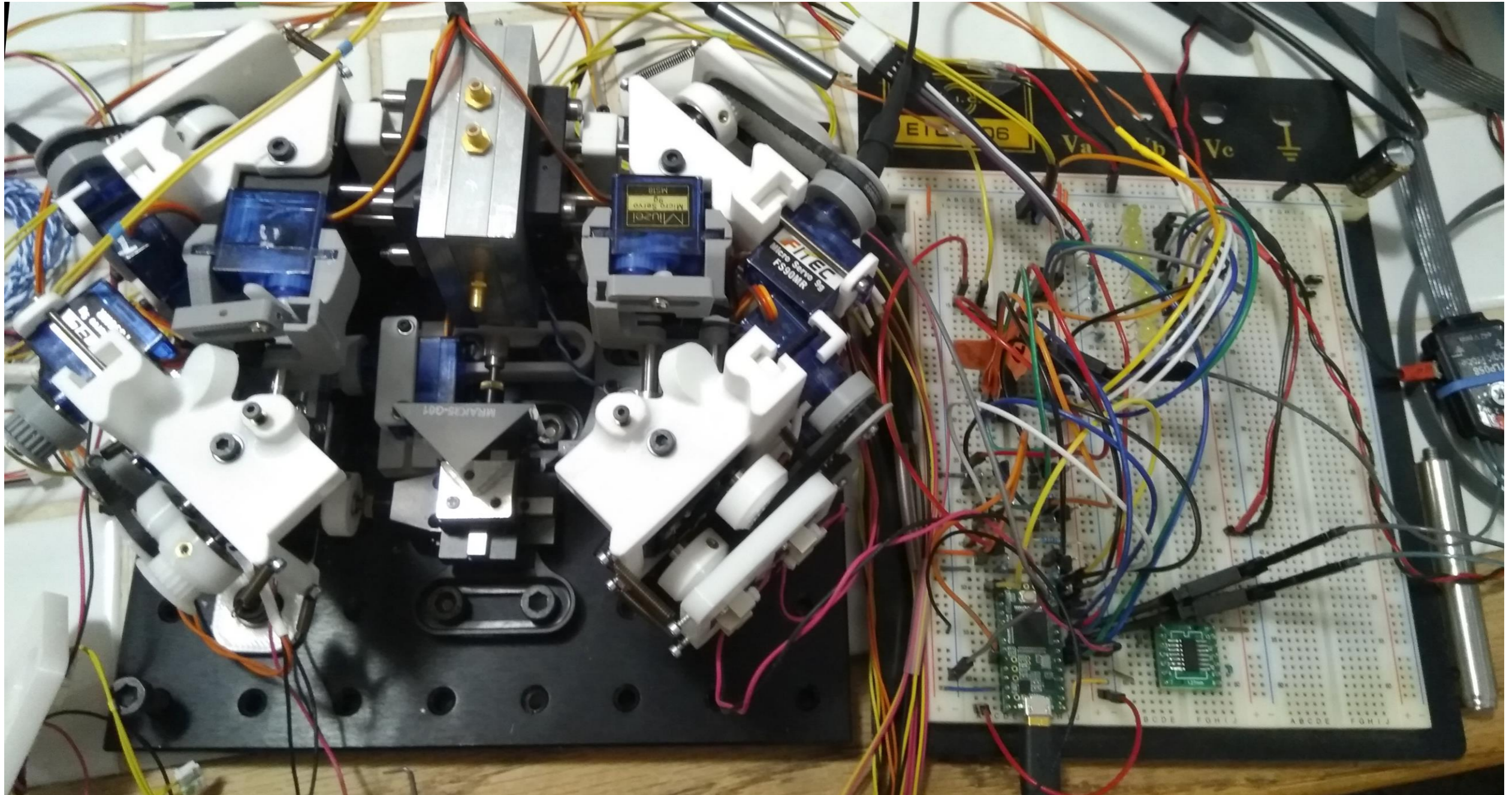
GEN3 4Ch Muxer



GEN3 MCU Controller

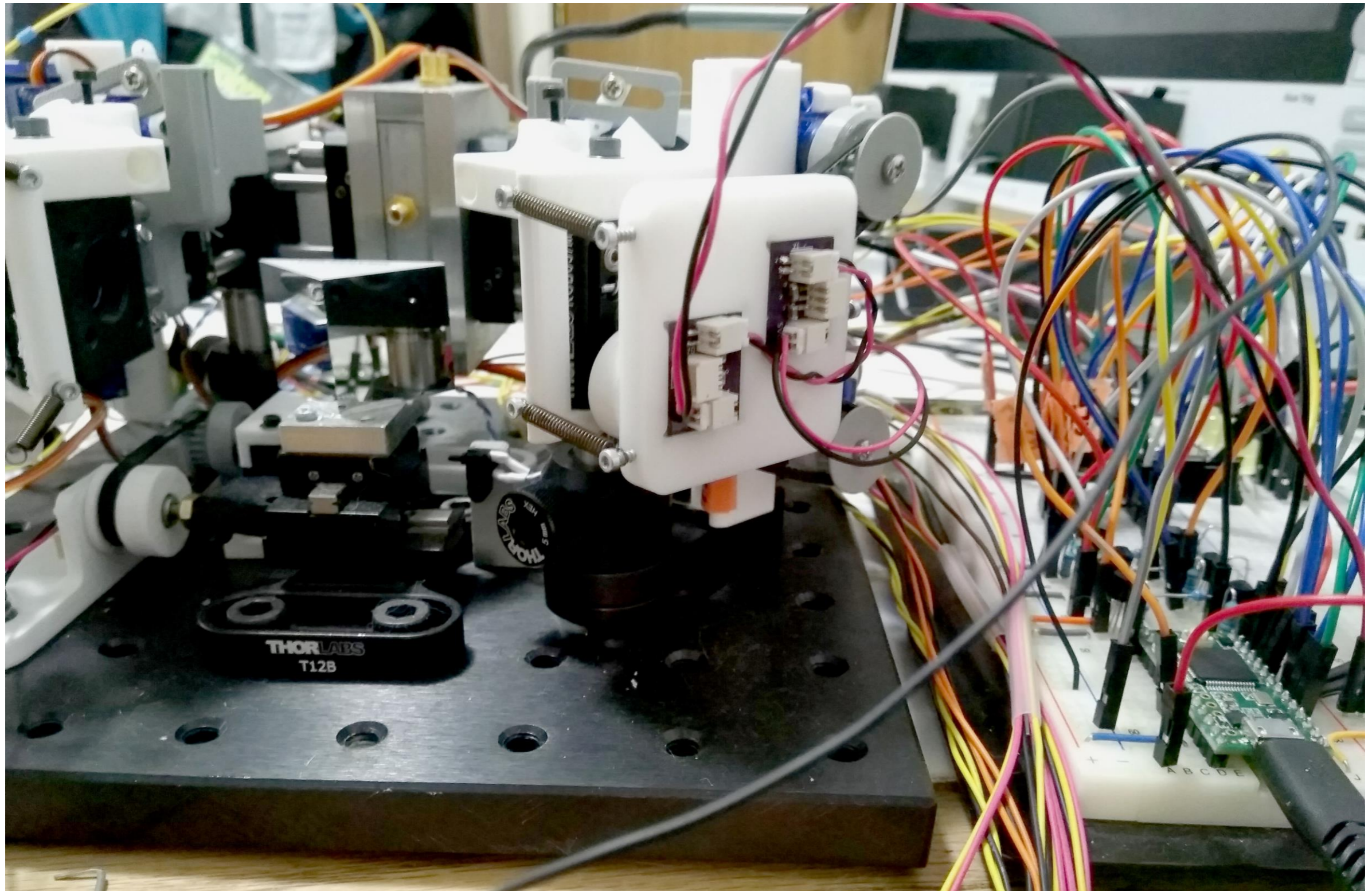
Detector Progress

GEN3 Development Board



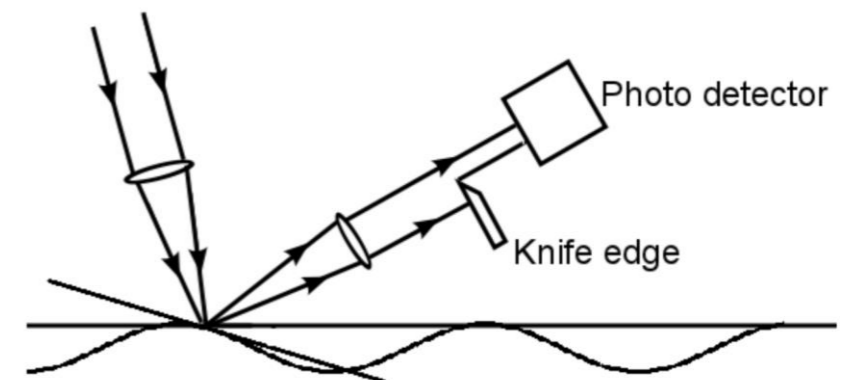
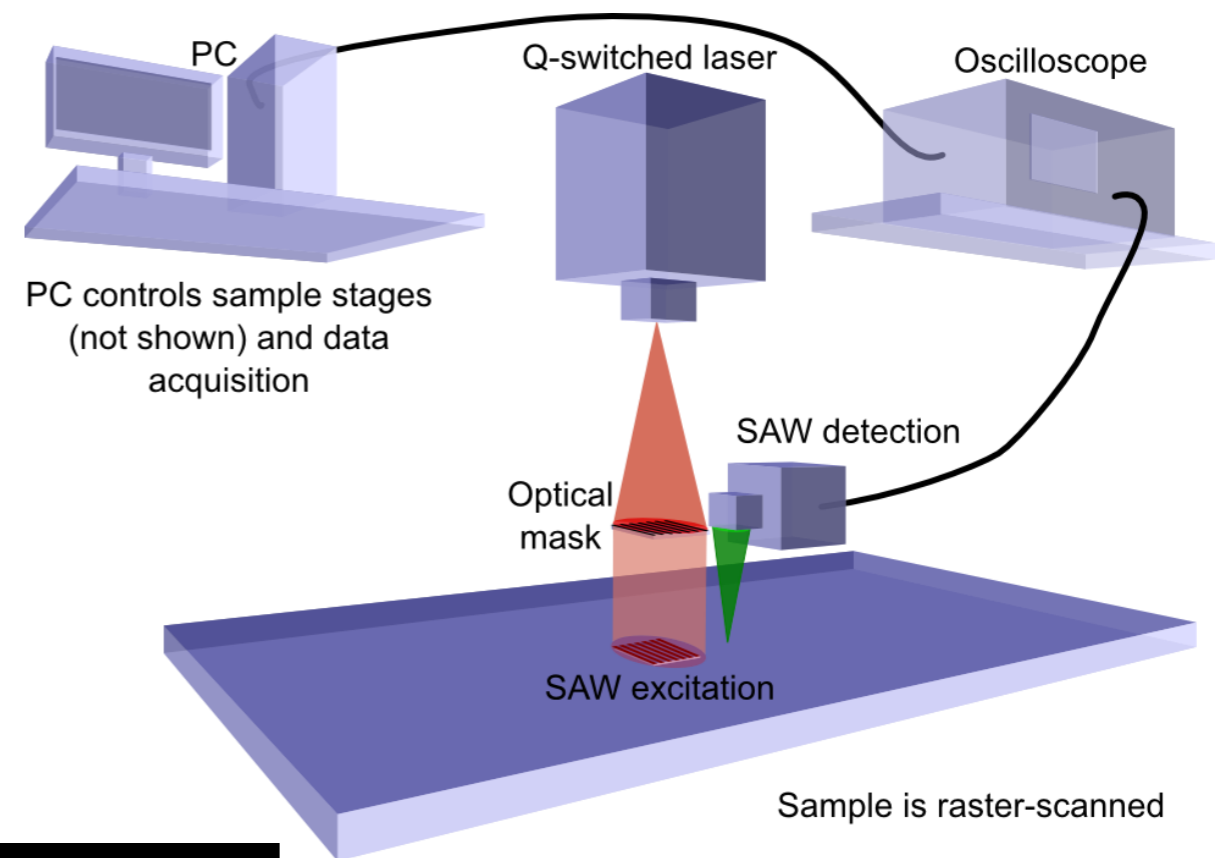
Detector Progress

GEN3 Development Board

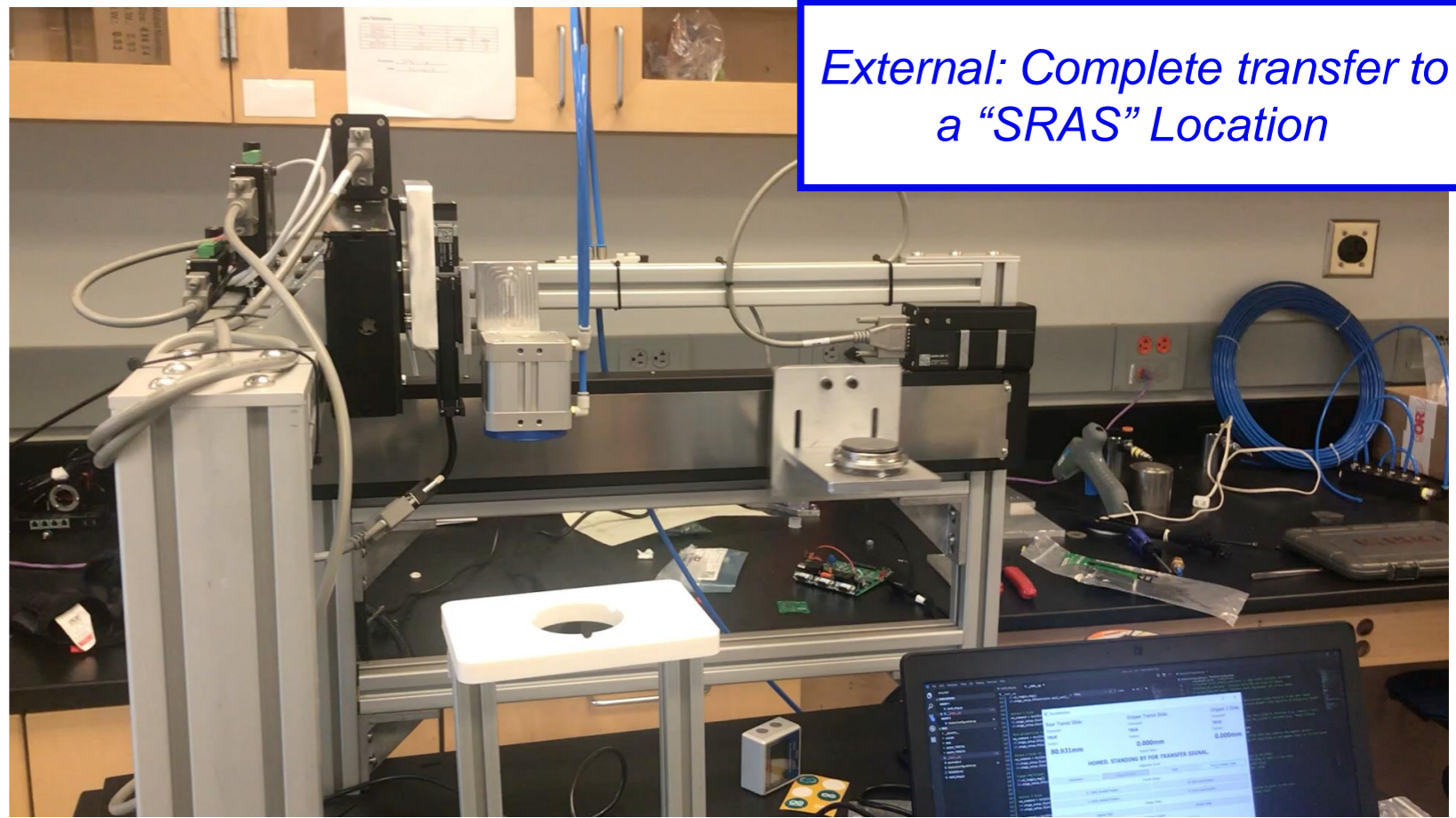


Extras

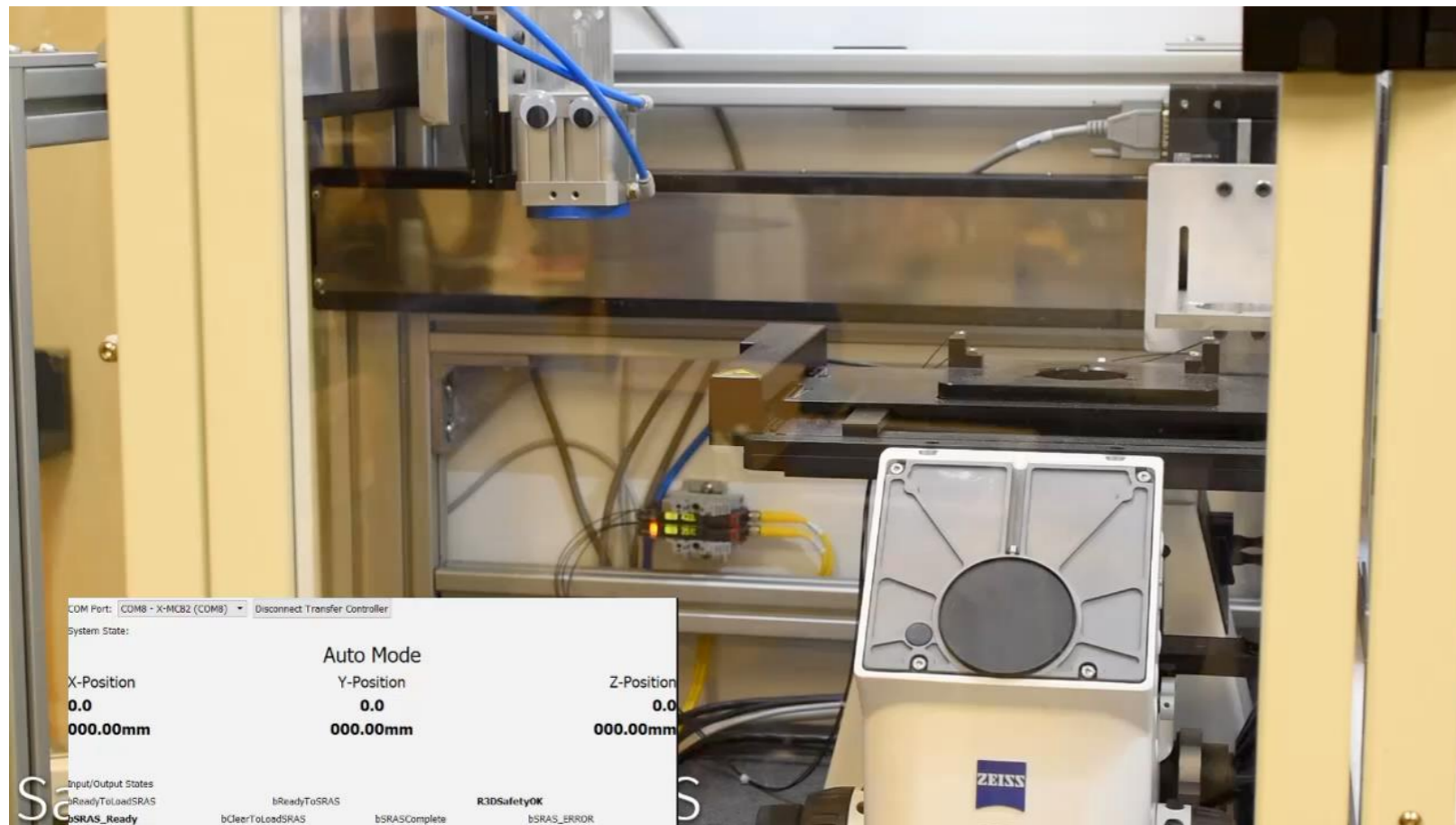
- At each point generate SAWs using *laser* and a *grating* – fixed acoustic wavelength
- Detect the SAWs with another laser
- Find the peak of the frequency spectrum of the detected waves
- Calculate the velocity using $v = f\lambda$



Automated robot transfer system



Below: Internal (no drop-off) with code. Precision of location.



Possibility: Expansion for other "drop off" sites. Ultrasound? X-Ray? SEM?